

DS19xx <u>i</u>Button Reliability Report

This report has been prepared by:

Dallas Semiconductor Quality Assurance Department Original Report: 10/06/93 1st Addendum: 6/10/96

Touch Memory Reliability Report October 6, 1993

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<u>Addendum</u>

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Change Appendix IV to include additional Reliability Monitor Products.

Appendix IV.

Reliability Monitor Results

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Add Appendix VII

Appendix VII

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1.0. Introduction: Goals of Reliability Program

Dallas Semiconductor's DS19xx Touch Memory reliability program is designed to evaluate the environmental stress factors that may affect the use of the DS19xx in customer applications. Most tests attempt to reflect environmental abuse that might occur in applications such as medical, industrial, and human handling. In some devices (DS1990A, DS198X) only a silicon integrated circuit is contained within the MicroCan. In other devices (DS1494/DS1991/DS1992/DS1993/DS1994) a lithium energy source is combined with the integrated circuit and sealed inside of the MicroCan enclosure. The DS1494/DS1994 also has a quartz crystal inside to support the timekeeping functions. Therefore, separate reliability studies have been conducted on the assembled Touch Memory devices, the integrated circuits, and the lithium energy source. The qualification goals for each process are as follows:

- (1) Packaged DS19xx device qualification
 - Storage life, +85 deg C, 1000 hrs
 - Moisture soak, 60 deg C at 90% R.H., 1000 hrs
 - Temperature cycling, -40 to +85 deg C, 1,000 repetitions
 - Mechanical shock, Mil-Std-883C, Method 2002
 - Mechanical vibration, Mil-Std-883C, Method 2005
 - Salt atmosphere exposure, Mil-Std-883C, Method 1009
 - Grommet integrity
 - Environmental studies (handling use, outdoor exposure, water immersion)
- (2) DS19xx die qualification
 - Burn-in, +125 deg C, 7.0 volt bias, 1000 hours, dynamic excitation
 - Storage life, +85 deg C, 1000 hrs
 - Moisture soak, 70 deg C at 90% R.H., 1000 hrs
 - Temperature cycling, -40 to +85 deg C, 1000 repetitions
- (3) Battery cell qualification
 - Storage life
 - Seal integrity
 - Moisture resistance
 - Capacity
 - Safety
 - Performance
 - Incoming Q.C.

This report will tend to use the DS1994L-F50 which uses the BR1225 lithium cell and a 32Khz crystal as a vehicle to determine reliability results related to devices that contain a lithium energy source. Other devices that contain a lithium cell will be a subset of the DS1994L-F50. The DS1990-F30 will tend to be the vehicle to determine reliability results related to devices that are entirely passively powered (parasite-powered).

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2.0. DS19xx Touch Memory Family Characteristics

A Touch Memory is a ruggedized data carrier that can be used in many diverse applications such as access control, work-in-progress, field maintenance tracking, event logging and security. Because of this diversity of use, the DS19xx Touch Memory has been constructed to be highly durable, resisting a variety of environmental effects such as moisture, temperature, shock, vibration, and corposion.

2.1. Physical Construction

A Touch Memory is an electronic circuit housed in a stainless steel enclosure called a MicroCan which resembles a typical coin-cell battery in appearance. The material thickness is 0.254mm (10 mil). The two conductive surfaces of the MicroCan are separated by a polypropylene grommet which serves as an electrical insulator. Inside, the substrate on which the integrated circuit (IC) is mounted makes contact to one surface of the MicroCan by touching it directly, the other MicroCan surface is connected by a spring bias to contact points on the substrate. Normal IC wire-bonding techniques connect the bond pads of the IC to the substrate. A second spring bias is present in devices that contain a lithium energy source, where this second spring serves to connect the positive voltage of the battery to the substrate. The details of this construction are illustrated on the next page.

2.2.1. Type 305 Stainless Steel

Composition:		Physical Constants:	
Carbon	0.12% max	Specific Gravity	8.03
Manganese	2.00% max	Density (lb/in ³)	0.29
Phosphorus	0.045% max	Coeff. of Therm. Expan.	
Sulfur	0.03% max	(cm/cm/°C x 10-6)	19.0
Silicon	1.00% max	Electrical Res. (microhm-c	m)75.6
Chromium	17.00/19.00%	,	
Nickel	10.50/13.00%		

Type 305 stainless steel is used in all of the standard (non-magnetic stainless) Touch Memory products. Type 305 stainless steel is used extensively for parts produced by deep drawing. Its nonmagnetic properties recommend it for electrical instruments, and its high corrosion resistance makes it ideal for use in textile and chemical processing equipment. It resists nitric acid well and sulfuric acid solutions moderately well. It is satisfactory for use with a wide variety of organic and inorganic chemicals, foodstuffs, and sterilizing solutions.

2.2.2. Type 430F Stainless Steel

Composition:		Physical Constants:	
Carbon	0.12% max	Specific Gravity	7 75

Manganese Phosphorus	1.25% max 0.06% max	Density (lb/in ³) 0.28 Coeff. of Therm. Expan.
Sulfur or Selenium	0.15% min	(cm/cm/°C x 10-6) 11.9 Electrical Res. (microhm-cm) 60
Silicon	1.00% max	
Chromium	14.00/18.00%	
Molybdenum	0.60%	

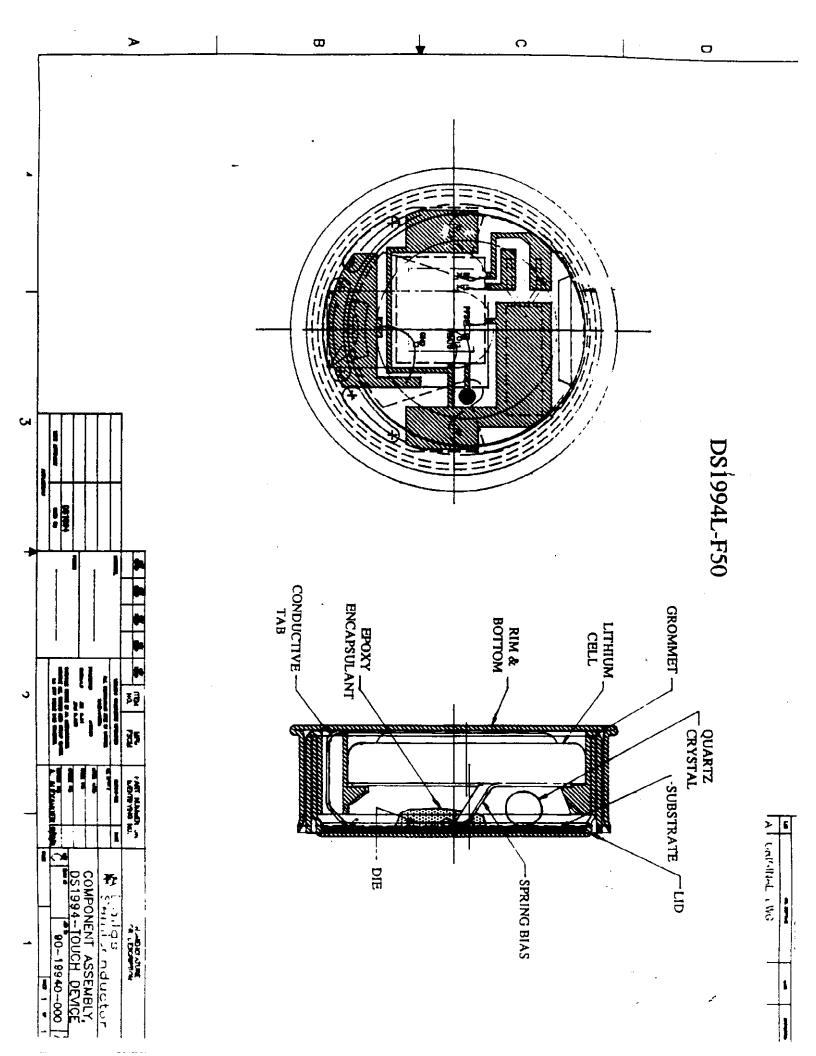
Type 430F stainless is used in all of the "magnetic" stainless steel — h Memory product options. They are specified by the suffix "M" in the product identifier. (For example, a DS1994L-F50 is type 305 "non-magnetic" stainless steel and a DS1994L-F5M is type 430F "magnetic" stainless steel. These two products are identical except for the composition of the stainless steel MicroCan.) The type 430F stainless steel composition was chosen to permit the magnetic attraction of Touch Memories in applications where a magnetic probe or holder is desirable. The other properties of type 430F stainless steel are similar to type 305 described above.

2.3. Polypropylene Grommet

The insulating grommet is molded from a polypropylene homoplymer resin that has a carbon black additive to inhibit breakdown due to ultraviolet light. The material was chosen for its high resistance to solvents, chemicals, and environmental stress-cracking. It also has a high degree of stiffness and good heat-age life. It is typically used in automotive products, housewares, and general molding items. It also meets all of the FDA criteria for safe use in components intended for food-contact use, including cookware.

Typical properties:

Water absorption after 24 hours: 0.02% (ASTM Method D 570) Environmental stress-cracking: >500 hrs, no failures (ASTM Method D 1693).



3.0. DS19xx Temperature Stress

3.1.1. Storage life - Parasite-powered devices

Description of test: Exposure of the DS1990-R30 to a +85°C environment with no

electrical bias on the devices. The DS1990-R30 is representative of the type of Touch Memory that is powered entirely from the

reader.

Duration of test:

1000 hours

Sample size:

225

Results:

No failures. Operation was unaffected and ROM data was retrieved with no errors. See Appendix I for details.

3.1.2. Storage life - Lithium-powered devices

Description of test: Exposure of the DS1994L-F50 to a +85°C environment with no

electrical bias on the devices. The DS1994L-F50 is representative of the type of Touch Memory that is powered partially from the

reader and partially from an internal lithium supply.

Duration of test:

1000 hours

Sample size:

224 devices total chosen from two different lots of material.

Results:

No failures. Operation was unaffected and data test pattern was retrieved with no errors. See Appendix II for details. (Note: The product qualification process requires that devices pass 1000 hours of +85°C stress without failure. The stress test was

continued out to 2000 hours with no failures recorded.)

3.2.1. Temperature cycling - Parasite-powered devices

Description of test: Temperature cycling of the DS1990-F30 from -40°C to +85°C with

no electrical bias on the devices. A cycle consists of a dwell of approximately ten minutes at each temperature extreme with a fifteen minute transition time between the extremes. The DS1990-F30, DS1990-R30 and DS1990A-F50 are representative of the type

of Touch Memory that is powered entirely from the reader.

Duration of test:

Group A: 2000 cycles Group B: 2000 cycles

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Group C: 1000 cycles

Sample size: Gro

Group A: 75 DS1990-F30 Group B: 75 DS1990-R30 Group C: 150 DS1990-R30

Results:

No failures. Operation was unaffected and ROM data was retrieved with no errors. See Appendix I for details.

(Note: The product qualification process requires that devices pass 1000 hours of temperature cycling stress without failure. The stress test was continued out to 2000 hours for Group A and Group

B with no failures recorded.)

3.2.2. Temperature cycling - Lithium-powered devices

Description of test: Temperature cycling of the DS1994L-F50 and the DS1994L-F5M

from -40°C to +85°C with no electrical bias on the devices. A cycle consists of a dwell of approximately ten minutes at each temperature extreme with a fifteen minute transition time between

the extremes. The DS1994L-F50 and DS1994L-F5M are representative of the type of Touch Memory that is powered partially from the reader and partially from an internal lithium

supply.

Duration of test:

1000 cycles

Sample size:

328 devices total chosen from four different lots of material.

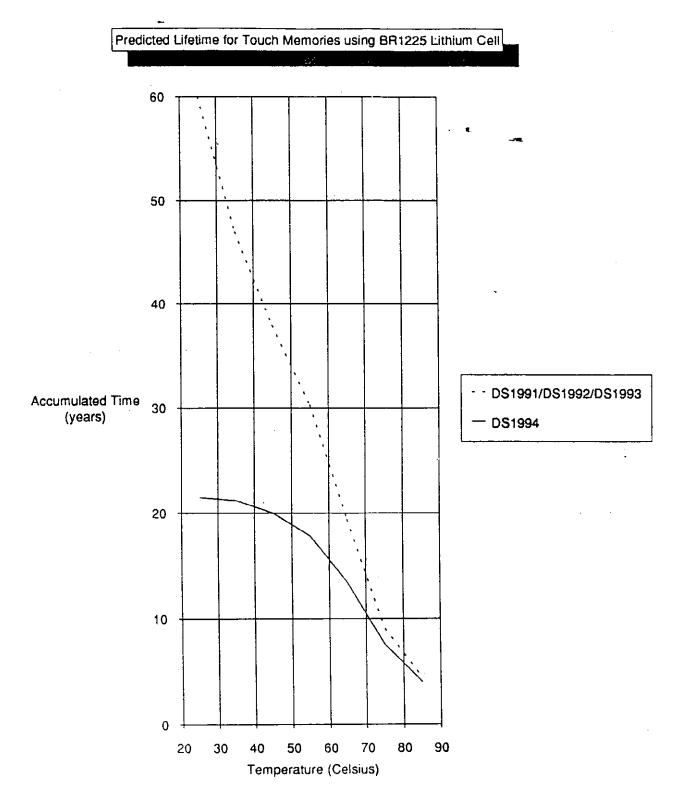
Results:

No failures. Operation was unaffected and data test pattern

was retrieved with no errors. See Appendix II for details.

3.3. Temperature affect on predicted product lifetime

The integrated circuit within each Touch Memory has greater leakage current at elevated temperatures and therefore demands more energy from the lithium supply. This results in a reduced lifetime for the device. The graph shows the relationship between temperature and lifetime. There are two general classes of lithium-powered devices, those with an oscillator used for timekeeping (DS1994) and those that do not have an oscillator (DS1991/DS1992/DS1993).



4.0. DS19xx Moisture/Humidity Stress

4.1.1. Moisture soak - Parasite-powered devices

Description of test: Exposure of the DS1990-F30 to a 60°C/90% relative humidity

environment and the DS1990-R30 to a 70°C/90% relative humidity

environment with no electrical bias.

Duration of test: Group A: 960 hours

Group B: 480 hours

Sample size: Group A: 75 DS1990-F30

Group B: 225 DS1990-R30

Results: No failures. Operation was unaffected and ROM data

was retrieved with no errors. See Appendix I for details.

4.1.2. Moisture soak - Lithium-powered devices

Description of test: Exposure of the DS1994L-F50 and DS1994L-F5M to a

60°C/90% relative humidity environment with no electrical bias.

Duration of test: 960 hours

Sample size: 360 devices total chosen from four different lots of material

Results: No failures. Operation was unaffected and data test pattern

was retrieved with no errors. See Appendix I for details.

4.2. Salt atmosphere exposure

Description of test: Exposure of the DS1994L-F50 and DS1994L-F5M to a

salt spray according to Mil-Std-883C, Method 1009, Cond. C. with no electrical bias. Five units of DS1994L-F50 (type 305 stainless) and five units of DS1994L-F5M (type 430 stainless) were used in

the testing.

Duration of test: 96 hours

Sample size: 10 devices

Results: No failures. Operation was unaffected and data test pattern

was retrieved with no errors.

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Readpoint:

24 hours

DS1994L-F5M: All 5 have slight rusting at grommet sight, with an average of 75% of grommet circumference affected. Two have a rust stream across the device.

DS1994L-F50: 2 of 5 devices have slight rusting, appears to have migrated from DS1994L-F.M uevices that were in close proximity.

Readpoint:

48 hours

DS1994L-F5M: All 5 have medium to heavy rusting at grommet sight. All 5 have rust that runs across the device.
DS1994L-F50: 4 of 5 devices have slight rusting on 50% of the grommet area.

Readpoint:

96 hours

DS1994L-F5M: All 5 have heavy rusting at grommet sight, 100% of the circumference affected on 3 devices, 75% on the others. Also heavy rust running across the top and down the sides of the MicroCan.

DS1994L-F50: 4 of 5 devices have slight rusting on 50% of the grommet area.

4.3. Immersion in saline water

Description of test:

Immersion of DS1991L-F5 devices in saturated saline solution.

then wiped dry before reading with DS9092GT probe.

Duration of test:

24 hour immersion

Sample size:

10 devices

Results:

No failures. Operation was unaffected and data test pattern

was retrieved with no errors. Slight loss of brightness noted on

some devices.

5.0. DS19xx Physical Stress

5.1.1. Mechanical Shock - Parasite-powered devices

Description of test: Mechanical shock testing performed on the DS1990-F30 and

DS1990A-F50 using Mil-Std-883C, Method 2002.3, Condition A.

in all three axes at 500g's.

Duration of test:

18 cycles

Sample size:

15 DS1990-F30 15 DS1990A-F50

Results:

No failures. Operation was unaffected and ROM data was retrieved with no errors and the physical appearance was unchanged. See Appendix I for details. (A machanisal should be all and a machanisal should be a machanisal

unchanged. See Appendix I for details. (A mechanical shock of 500g's is roughly equivalent to a drop onto a hard surface from a

height of 1.5m (5ft).

5.1.2. Mechanical Shock - Lithium-powered devices

Description of test: Mechanical shock testing performed on the DS1991L-F50 using

Mil-Std-883C, Method 2002.3, Condition A. in all three axes. Group A received 500g's, Group B received 1500g's, Group C

received 3000 g's.

Duration of test:

18 cycles

Sample size:

90 devices total chosen from three different lots of material.

Group A: 70 pieces; Group B: 10 pieces; Group C: 10 pieces

Results:

No failures. Operation was unaffected and data test pattern was retrieved with no errors and the physical appearance was unchanged. See Appendix II for details. (A mechanical shock of 500g's is roughly equivalent to a drop onto a hard surface from a height of 1.5m (5ft), and a shock of 3000 g's is roughly equivalent

to

a drop from a height of two stories.)

5.2.2. Vibration - Parasite-powered devices

Description of test: Vibration testing performed on the DS1990-F30 and DS1990A-

F50 using Mil-Std-883C, Method 2005, Condition A. Testing was performed in all three axes, with the frequency varied from 10Hz

to 55Hz and amplitude of 3mm (0.12 in).

Duration of test:

96 hours

Sample size:

33 DS1990-F30

33 DS1990A-F50

Results:

No failures. Operation was unaffected and ROM data

was retrieved with no errors and the physical appearance was

unchanged. See Appendix I for Jetails.

5.2.2. Vibration - Lithium-powered devices

Description of test:

Vibration testing performed on the DS1991L-F50 and DS1994L-F5M using Mil-Std-883C, Method 2005, Condition A. Testing was performed in all three axes, with the frequency varied from

10Hz to 55Hz and amplitude of 3mm (0.12 in).

Duration of test:

96 hours

Sample size:

33 DS1991L-F50

33 DS1994L-F5M

Results:

No failures. Operation was unaffected and data test pattern was retrieved with no errors and the physical appearance was

unchanged. See Appendix II for details.

5.3. Crush Test

Description of test:

DS1991L-F50 subjected to direct weight of 114kg (25 lb) placed on

lid of can, evenly distributed.

Duration of test:

30 seconds

Sample size:

10 devices

Results:

No visible can damage. Data test pattern retrieved with no errors.

5.4. Contact Durability

Description of test:

A DS1991L-F50 was mounted on a pneumatic piston that inserted the device into a rigidly affixed DS9092 probe that was connected to a PC thru a DS9097 Serial Port Adapter. The DS1991L-F50 was read on each insertion. The insertion force was estimated to be

a maximum of 67N.

Duration of test:

1 million insertions

Sample size:

I device

Results:

Operation of Touch Memory and probe was unaffected and data test pattern was retrieved with no errors. Some minor denting and deformation of the DS1991L-F50 was observed. Significant wear occurred on the ground contact ring and the center contact of the DS9092 Touch Probe but it was not worn completely through and was still functional.

5.5. Tensile Attachment Strength

This test characterizes the strength of the DS9096P self-stick pads as an attachment method. Tensile strength measures the resistance of the tape to being pulled off in a direction perpendicular to the mounting surface plane. The tape pad vendor has indicated that this parameter will exceed 100 psi tensile pull strength.

5.6. Solderability

Do not solder directly to the surfaces of the MicroCan. The stainless steel is not solderable. Dallas Semiconductor supplies printed circuit board mounting clips (DS9094F) and snaps (DS9098) so that direct soldering can be avoided.

6.0. Environmental/Handling Stress

In order to evaluate the performance of the Touch Memory devices in typical real-world applications, additional testing was performed beyond the standard temperature and moisture acceleration studies. These tests provide quantitative data to drive ongoing improvements in the overall design.

6.1. Outdoor Daily Exposure

This test is designed to expose the DS19xx Touch Memory devices to a outdoor environment which presents a variety of typical stresses such as temperature (-10°C to 40°C), humidity, rain, dust, UV irradiation, and air pollution.

Description of test: Devices programmed with test pattern and placed on roof with

direct sunlight exposure.

Duration of test: Ongoing - Start date June 1991.

Sample size: 75 DS1991L-F5's.

Readpoints: • Every 168 hours.

Results: Failure Type: One unit developed a cracked grommet after 99

weeks (16,632 hours) which allowed moisture to penetrate and short the Data contact to Ground.

Corrective Action: Grommet design on the failed unit was of

the original polyethylene type. Grommet material was changed to polypropylene with additives to enhance UV resistance. All units produced after March 1, 1993 have polypropylene grommets.

Remaining 74 units are still under test and have reached 121 weeks (20,328 hours) with no additional failures, data test pattern was retrieved with no errors. Physical appearance shows some deterioration of the grommets where the exposed polyethylene material is powderized. Test will be an action indefinitely.

on-going indefinitely.

6.2. Handling Use

This test is designed to expose the DS19xx Touch Memory devices to typical daily human handling as part of an access control system at Dallas Semiconductor. All Dallas Semiconductor employees now use the DS1994L-F50 device attached to their photo-ID badge as a means of entering all secured doors. Each time they enter a door, the system reads the 64-bit lasered ROM to grant access as well as performing a data integrity test on the contents of the device. This information is automatically recorded by the system and is monitored by the MIS department at Dallas to identify failed Touch Memory devices. The ID badges are subjected to a wide range of conditions, incurring coming in contact with a variety of clothing materials, being left on automobile dashboards in direct sunlight, getting placed into a pocket or purse, and occasionally going through a clothes washer. The results of this on-going test are summarized below.

Description of test:

Devices in Group A are DS1994L-F50 programmed with a test pattern and real-time clock running. Each time an employee enters a secured door the data pattern is tested and timekeeping accuracy is checked. A second group of employees carries badges with two Touch Memories affixed, one DS1994L-F50 (Group B) and one DS1991L-F50 (Group C). Badges that are in Group B and Group C are checked for data integrity of the test pattern. In addition, the ability to write data correctly in a dynamic environment is tested by writing 32 bytes of new information to the badge each time a secured door is entered and then reading back and confirming the new information. Group B is also checked for timekeeping accuracy. Total number of transactions to date is 504,198.

Sample size:

Group A: 900 DS1994L-F50 mounted on photo ID badges Group B: 100 DS1994L-F50 mounted on photo ID badges

Group C: 100 DS1991L-F50 mounted on photo ID badges

Readpoints:

Each time a secured door is entered (2-8 times a day)

Results:

Group A: 436,628 transactions completed in 10 months. (Read of

data plus clock accuracy.)

No data errors during transactions. No clock accuracy errors.

17 devices returned:

Failure type:

Unable to communicate with 15 units due to an early version of the silicon chip contained in the DS1994L-F50 that would prevent access to the device if subjected to certain ESD conditions. A procedure was developed to externally reverse this condition in the chip and confirm that the data and timekeeping registers were not corrupted.

Corrective Action: Silicon chip was modified and this failure mode has not been observed with current version of the DS1994L-F50. All units produced after March 1, 1993 have this version of the silicon chip.

Failure type: One unit developed an internal short.

Corrective Action: Failure appears to be random. No design changes made.

Failure type: One unit failed due to moisture pencuration as a result of being put thru a clothes washing machine. Unit became functional again after a period of several days.

Corrective Action: No design changes made.

Group B: 36,552 transactions completed in 14 months. (Read and write of data plus clock accuracy.)

No data errors during transactions. Two clock accuracy errors.

3 devices returned:

Failure type: One unit failed due to a mechanical stress placed on the device when pressed into an employee badge causing intermittent operation.

Corrective Action: Press fit procedure reviewed. No design changes made.

Failure type: Two units experienced timekeeping errors believed to be caused by an ESD event causing a 6 hour error in one case and an 18 hour error in the other. Data test pattern was retrieved with no errors.

Corrective Action: Timekeeping oscillator is high impedance and under certain conditions will be subjected to disturbances. No design changes made.

Group C: 31,018 transactions completed in 14 months. (Read and write of data.)
No data errors during transactions.

1 device returned:

Failure type: One unit initially would not allow entry. Device was believed to have been programmed incorrectly from the start of the test, but was inadvertently reprogrammed before the cause could be investigated.

Corrective Action: Device was placed back into study after proper initialization and has not exhibited any problems.

6.3. Electrostatic Discharge (ESD)

Description of test: Testing done with an IMCS 5000 ESD tester using Mil-Std-883C

Method 3015.7 (Human Bc dy Model: 100pf thru 1500 ohms).

Duration of test:

3 pulses of +10KV, 3 pulses of -10KV

Sample size:

Total of 9 DS1991L-F50 chosen from three separate lots. Total of 9 DS1994L-F50 chosen from three separate lots. Total of 9 DS1990A-F30 chosen from three separate lots.

Results:

No failures. Operation was unaffected and data test pattern

was retrieved with no errors.

6.4. Effects of Magnetic Fields

Description of test: Devices were magnetically attracted and held to a large permanent

magnet for the duration of the test, except during the reading of the stored and data and the timekeeping registers. The testing occurred at room temperature. The magnet was capable of completely erasing a 5.25", 1.2M floppy disk when passed within a few millimeters of the disk for approximately 30 seconds. After being subjected to the magnet, the floppy disk was unrecognizable to a

PC, including any formatting information.

Duration of test:

168 hours

Sample size:

25 DS1994L-F5M

Results:

No failures. Operation was unaffected and data test pattern

including timekeeping information was retrieved with no errors.

6.5. Intrinsically Safe Certification

Description of test: UL #913 - Intrinsically Safe Apparatus.

Testing done by MET Labs/NRTL, Project Number: SAF128

Listing Number: DAL0913

Products evaluated: DS1990, DS1991, DS1992, DS1993, DS1994

Results:

Above products are designed to allow for storage and retrieval of information by touching the MicroCan surfaces with a wand

interface and computer approved under the entity concept and

meeting the electrical ratings marked on the products (see below for a sample marking). The above products have been approved under the entity concept for use in Class I, Division I, Groups A,B,C, and D Locations. See Appendix III for details. For the complete listing report contact Dallas Semiconductor.

Sample marking required for Intrinsically Safe Applications:

Vmax = 15 V

 $Li = 18 \mu H$

Imax = 10 mA

Ci = 0.2 nF

7.0. IC Qualification Data

7.1.1. High Voltage Accelerated Life Stress - Parasite-powered devices

Description of test: Device is exposed to a +125°C environment and is operated with

Vcc = 7.0 volts. The parts are exercised continuously during testing. The DS914 and D3915 are representative of the type of integrated circuit used in a Touch Memory that is powered entirely

from the reader.

Duration of test: Group A: 48 hours; Group B: 96 hours; Group C: 1000 hours;

Group D: 504 hours; Group E: 72 hours; Group F: 1072 hours

Sample size: DS914 A1: Group A: 1394; Group B: 898; Group C: 444

DS914 A2: Group D: 196

DS915 A2: Group E: 490; Group F: 77

Results: One device failure in approximately 290 million equivalent device

hours at 55°C. When combined with the Operating Voltage Accelerated Stress data the resulting failure rating is 7 Fits. See

Appendix I for details.

7.1.2. High Voltage Accelerated Life Stress - Lithium-powered devices

Description of test: Device is exposed to a +125°C environment and is operated with

Vcc = 7.0 volts. The parts are exercised continuously during testing. The DS2404 is representative of the type of integrated circuit used in a Touch Memory that is powered partially from

the reader and partially from an internal lithium supply.

Duration of test: Group A: 48 hours; Group B: 1000 hours

Sample size: Group A: 784; Group B: 154

Results: Three device failures in approximately 65 million equivalent device

hours at 55°C. When combined with the Operating Voltage Accelerated Stress data the resulting failure rating is 51 Fits. See

Appendix II for details.

7.2.1. Operating Voltage Accelerated Life Stress - Parasite-powered devices

Description of test: Device is exposed to a +125°C environment and is operated with

Vcc = 5.0 volts. The parts are exercised continuously during testing. The DS914 is representative of the type of integrated

circuit used in a Touch Memory that is powered entirely from the reader.

Duration of test:

1000 hours

Sample size:

444

Results:

No device failures in approximately 33 million equivalent device

hours at 55°C. When combined with the High Voltage

Accelerated Stress data the resulting failure rating is 7 Fits. See

Appendix I for details.

7.2.2. Operating Voltage Accelerated Life Stress - Lithium-powered devices

Description of test:

Device is exposed to a +125°C environment and is operated with

Vcc = 5.0 volts. The parts are exercised continuously during testing. The DS2404 is representative of the type of integrated circuit used in a Touch Memory that is powered partially from

the reader and partially from an internal lithium supply.

Duration of test:

1000 hours

Sample size:

234

Results:

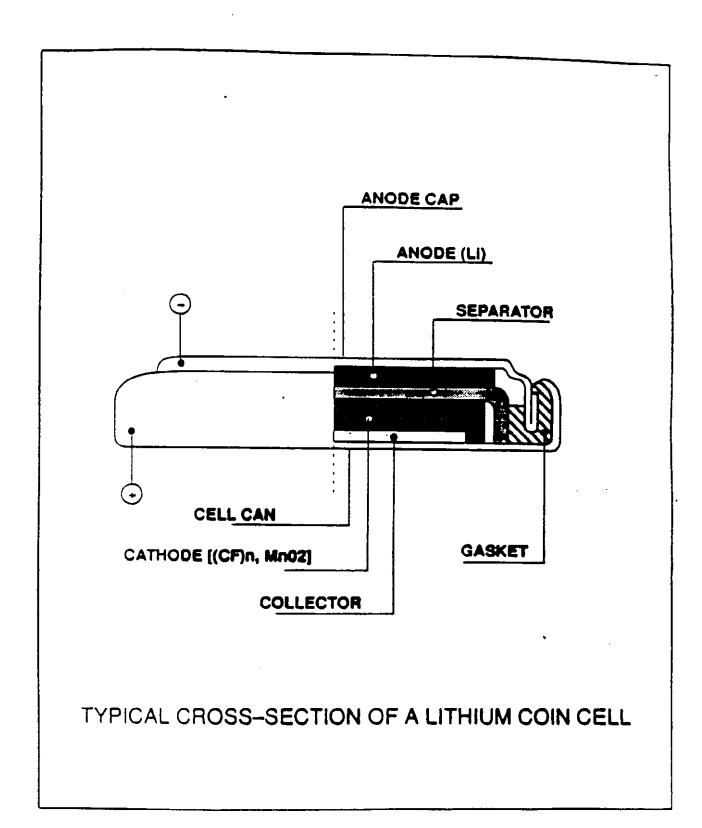
No device failures in approximately 18 million equivalent device

hours at 55°C. When combined with the High Voltage

Accelerated Stress data the resulting failure rating is 51 Fits. See

Appendix II for details.

- 8.0 BR1225 Lithium Cell
- 8.1. Cell cross-section



...... TOUCH MEMORY RELIABILITY REPORT

8.2. Cell qualification methods and procedures

The BR1225 used in all DS19xx devices that are lithium-powered has undergone an extensive qualification process at Dallas Semiconductor. The methods and procedures used to evaluate and qualify a cell are described below.

8.2.1. Storage Life

Purpose: Estimate the cell lifetime due to electrolyte evaporation as a function of

time.

be determined.

Method: Expose samples from at least three separate production lots to a minimum of three accelerated temperatures. The temperatures will be selected to accelerate electrolyte evaporation, yet not exceed absolute material or component limitations. This test is done on bare, untabbed cells, and the data consists of open circuit voltage and closed circuit voltage readings at various time intervals. The test is extended until at least 50% of each sample has reached a predetermined failing voltage level. This data is fitted into a log-normal distribution, and the values of $T_{1\%}$, $T_{50\%}$, and sigma are recorded. The data from each temperature exposure is analyzed for lot-to-lot variations, and, if insignificant, the combined data for each temperature is used to determine the Arrehenius activation energy for the cell system. This allows the lifetime prediction for the "use condition" to

8.2.2. Seal Integrity

Purpose: Evaluate the seal integrity over an accelerated range of temperature extremes.

Method: Expose samples from at least three separate production lots to a minimum of two accelerated temperature cycle conditions. Record open-circuit voltage (OCV) and closed-circuit voltage (CCV) for all cells at each readpoint, as well as magnified visual observations on a sample from each lot. Visual data is recorded for presence and location of salt formations, corrosion, the presence of liquid electrolyte, seal color and appearance, and cell deformation. Voltage distributions versus cycles is recorded, and used to establish performance baselines that will be compared to DS19xx devices undergoing the identical stress conditions.

8.2.3. Moisture Resistance

Purpose: Evaluate the cell performance with respect to a high humidity environment.

Method: Expose samples from at least three separate production lots to a single,

non-condensing, accelerated temperature/humidity storage condition. The temperature is chosen to be within the rated operating range for the cell. Record OCV and CCV values for all cells at each readpoint, as well as magnified visual observations on a sample from each lot. Visual data is recorded for presence and location of salt formations, corrosion, seal color and appearance, and cell deformation. Voltage distributions versus time are recorded, and used to establis a the effects of moisture resistance when compared to predicted nominal performance baselines that were established in the temperature-only storage life tests. Bare cell moisture resistance data will be compared to DS19xx devices unable oing the identical stress conditions.

8.2.4. Capacity

Purpose: Determine the statistical distributions of useable capacity within a lot, and

lot-to-lot.

Method: Discharge a sample of cells from each of three production lots into the

maximum rated load for the cell type to a predetermined cut-off voltage. Record the data for the maximum, minimum, and average capacity, as well as the standard deviation for each lot. Compare this same data for all three lots for significant variations. Open a sample from each discharged sample, and record cathode thickness, separator and anode appearance,

and presence of remaining electrolyte.

8.2.5. Safety

Purpose: Determine the safety aspects regarding the cell being qualified.

Method: Require the cell manufacturer to provide documented test results, independent laboratory data, material safety data sheets, and any other objective evidence that the cell under consideration has been tested for the

effects of:

External corrosion caused by leaking cells;

Toxicity of the cell components;

Heat rise or explosion due to shorting;

Safe operating exposure limits to solder heat;

Short and long term effects of various reverse charging currents;

Recommended and non-recommended methods of disposal.

8.2.6. Performance

Purpose: Determine the suitability-for-use of the cell with respect to existing or

planned assembly methods and product applications.

Method: Evaluate cell performance in the final product by collecting data in the following areas:

Open circuit voltage stability ove the temperature extremes encountered in manufacturing as well as the data sheet temperature ranges; Perform data retention tests at high and low temperature extremes to observe any presence of a "wake-up" phenomena;

Determine the compatibility with the MicroCan package by performing storage life, temperature cycle, and temperature/humidity tests on the final product, and compare visual and electrical results to those obtained on

bare cells:

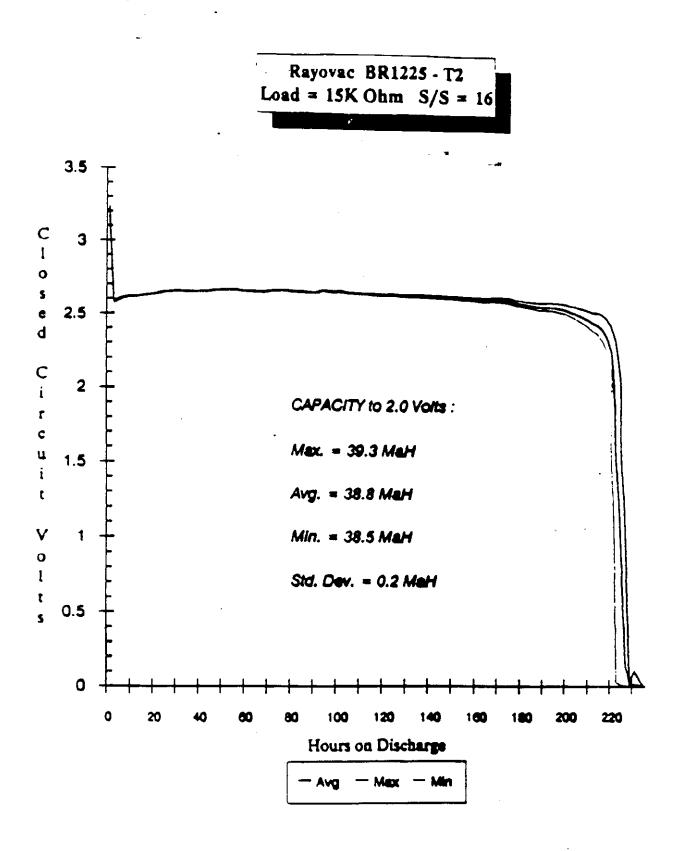
Evaluate the tab welding process for tab pull strength, as well as any residual damage to the cell electrodes by evaluating the long term OCV characteristics under ambient storage conditions.

8.2.7. Quality Specification

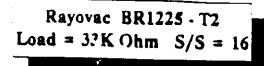
Purpose: Determine a mutually agreeable quality specification that can be applied to incoming material for the purposes of lot acceptance testing, and define the requirements for a qualified supplier.

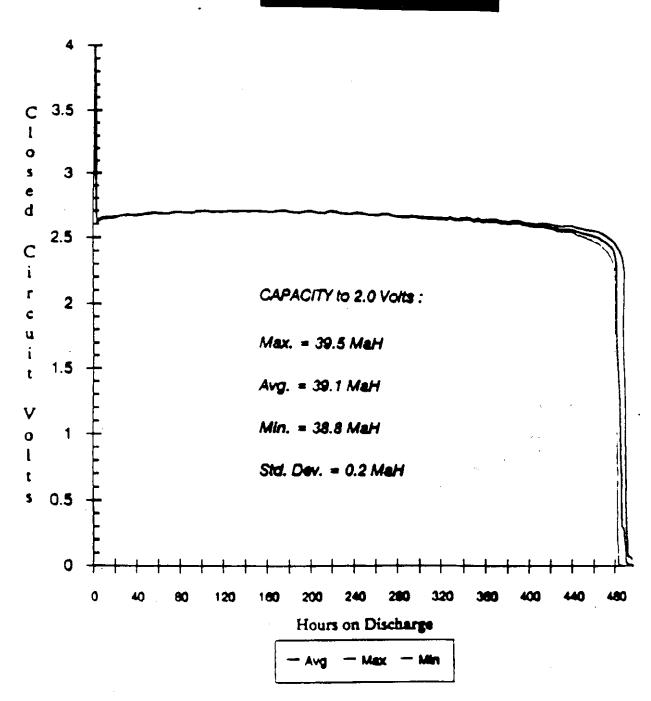
Method: Acceptance testing shall be based on correlation of electrical parameters between the cell vendor and the IQC department. This correlation will include open circuit voltage, closed circuit voltage, and capacity distributions. Lots submitted for correlation will have the mean values, as well as the distribution of these parameters identified based on data taken by the supplier. This data will be correlated and verified by testing of samples from these same lots. Once correlation is established, future shipments will be accepted on lot statistics supplied by the vendor, and verified with sampling at the IQC step. In addition, this mutually agreed specification will require a period of prior notification of any major changes, and will detail the requalification responsibility incurred as a result of the major changes.

8.3.1 Discharge test - 15K ohm load

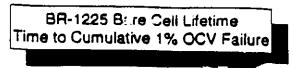


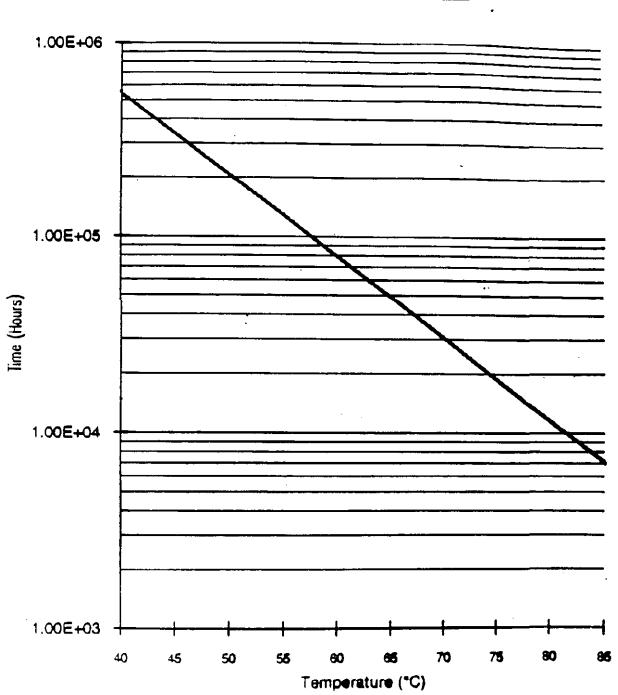
8.3.2 Discharge test - 33K ohm load



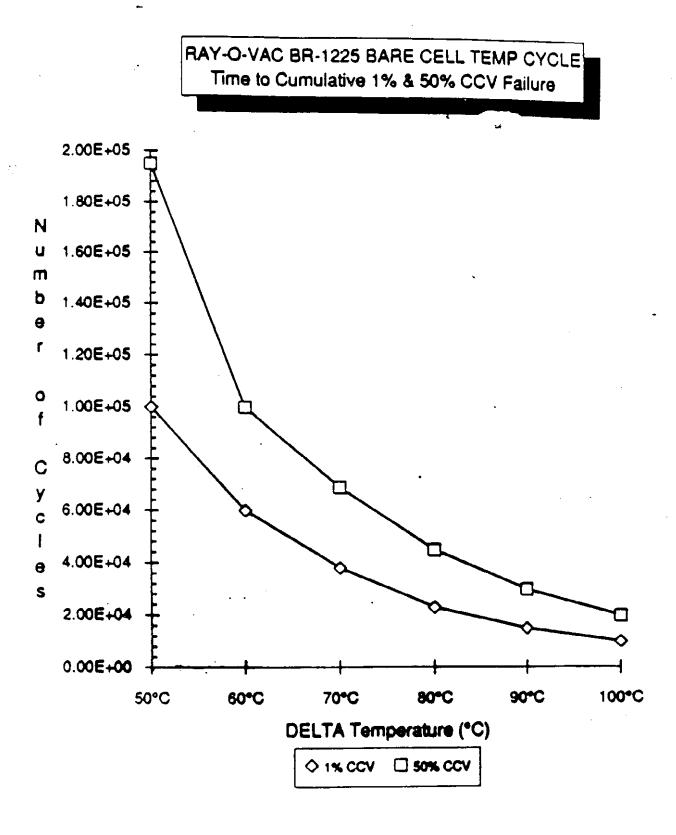


8.4. High temperature storage stress

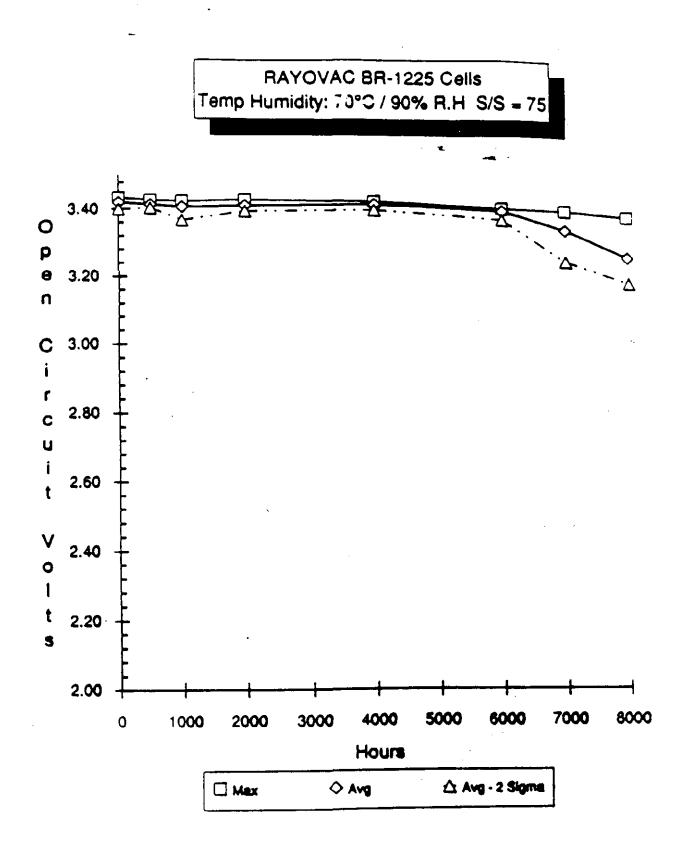




8.5. Temperature cycling stress



8.6. Temperature/humidity stress



8.7. Safety issues

Manufacturer supplied data covering a wide range of mechanical and electrical tests is available upon request from Dallas Semiconductor. A summary of the tests are listed below. No adverse effects were noted after any of the tests.

- 8.7.1. Mechanical Vibration Method 204C, M.I-S:d-202E; 0.06" double amplitude from 10 to 56Hz, and 10g peak from 57 to 500Hz. Vibration frequency was varied logarithmically from 10 to 500Hz and back to 10Hz over a 15 minute period.
- 8.7.2. Mechanical Shock 150g peak acceleration for 5 ms
- 8.7.3. Reduced Pressure (High Altitude) 10 days at 3mm Hg (equal to altitude of 37km or 122,00ft)
- 8.7.4. Drop Test Five drops onto concrete from a height of 102cm (40").
- 8.7.5. High Temperature Storage 70°C for 90 days
- 8.7.6. Hot Plate Test Temperature raised 5°C/minute up to 180°C without rupture, ignition, or explosion.
- 8.7.7 Thermal Shock +60°C for one hour followed by -10°C for one hour, repeated 60 times. Transition from one temperature extreme to the other is immediate.
- 8.7.8. Thermal Cycle +60°C for one hour, transition linearly for one hour to 10°C, dwell at -10°C for one hour, transition linearly for one hour back to +60°C; repeated 120 times.
- 8.7.9. Drilling Drilled diametrically with an electric drill with drill diameter 4 mm.

 Temperature rose due to short circuit but no rupture, ignition, or explosion occurred.
- 8.7.10. Crush Test Cells were crushed to half size diametrically with a hammer.

 Temperature rose due to short circuit but no rupture, ignition, or explosion occurred.
- 8.7.11. Burning Test Cells subjected to 1000°C flame from gas burner. Cells vented out and caught fire within 3 minutes, no explosion occurred.
- 8.7.12. Immersion Test Immersion in water and 5% salt water solution did not cause ignition.

- 8.7.13. Salt Water Spray Sprayed with 5% salt water solution and left for 8 hours. Rust was produced but no cell leakage.
- 8.7.14. Short Circuit Temperature rise was noted but no leakage or change in cell appearance.
- 8.7.15. Charge Test No leakage, rupture, or explorion occurred when cell was charged to 3% of the nominal capacity with 4µA of current.
- 8.7.16. Transportation Regulations Cells are authorized for all mode. Transportation provided that they are packaged in strong outside containers or boxes and are separated to prevent shorting, or installed in electronic devices. Exact wording of the U.S. Department of Transportation regulation can be found in Title 49, Code of Federal Regulations (49 CFR 173.206(f)).
- 8.7.17. Disposal Regulations Disposal of large quantities of lithium batteries should be performed by permitted, professional disposal firms knowledgeable in federal, state, and local hazardous materials and hazardous waste transportation and disposal requirements. The cells should never be incinerated or exposed to fire.

...... TOUCH MEMORY RELIABILITY REPORT

9.0. Reliability Monitoring Program

The Quality and Reliability department at Dallas Semiconductor performs a comprehensive set of tests at the point of product introduction to insure that all products meet a defined set of qualification standards. There is also an ongoing program to monitor the manufacturing processes which assures the customer that subsequent production lots meet the same high standards as those originally examined. This monitoring is accomplished by the Quality and Reliability department acting as an actual customer and placing a purchase order through a customer service representative. This guarantees that the units shipped from the stock room are randomly selected for the evaluation. The evaluation consists of three groups of 30 units each subjected to the set of tests as the original qualification. There are additional x-ray and dimensional checks done to insure that the assembly processes are still within specification. The results of the June 1993 monitor using the DS1992L-F50 as the test vehicle show no failures. The details can be found in Appendix IV.

Appendix I.

Notice of Qualification/Reliability Projection - DS1990A-F30/F50 and Related

DALLAS	
SEMICONDUCTOR	

EMICONDUCTOR
NOTICE OF QUALIFICATION
Date:
Product Type: DS1990A F30/50 Rev A1
Product Description: Touch Serial No.
Design Type:AutoID w/one wire port
Component Parts: DS915 IC, PC Board
Assembly Process Description: Dallas Semiconductor, Short (F30) & Tall (F50) Can
Package Type: Anode/Cathode Stainless Steel Flance Can w/Polypropylene Grommet
Reliability Process Flow: Module Products Flow
Reliability Failure rate (Fits): 28 Fits
Reliability File Nos: Q-8800, Q-9318
The above product has successfully completed qualification on this date and meets Dallas Semiconductor requirement, 05-00605-000, for Fully Qualified Production Product.
Residuality Engr. Manager Malulin But Director of Manufacturing Director of Assembly Engr. Director of Quality

RELIABILITY PROJECTION DS1990A F30/50 TOUCH SERIAL NO.

Assembly Technology: Metal Can

Sub Components: DS915 Touch Memory Chip, PC Board

Location: Dallas

Package Style: Anode/Cathode Short (F30) &

Tail (F50) Can w/Flange & Polypropylene Grommet

No. Pina: 0

Summary Data with Chi-Squared Distribution Assumed for IC's and Ea & B as noted below Stress Ambient Temperature & Voltage to

Fleid Ambient Temperature & Voltage

				Equivalent		
		Time	Sample	Dev. Hrs.	No. of	Falture Rate
Sub Component	Strees	(hre)	Size	● 55° C	Rejects	& Fall Mech.
DS914 A1	125°C, 7.0 V, Dyn.	48	1394	2.33E+07	1	F1
Touch Mem Chip		96	898	1.50€+07	0.	
D/C 9045, 9049, 91	07	1000	444	1.47E+06	0	
	125°C, 5.5 V, Dyn	1000	444	3.27E+07	Ö	
DS914 A2 DAC 9143	125°C, 7.0 V, Dyn.	504	198	3.43E+07	0	
DS915 A2	125°C, 7.0 V, Dyn.	72	490	1.23E+07	0	
D/C 9306		1072	77	2.68E+07	0	
Subtotals				2.9E+08	1	7 F

Print'd Crixt Board per MIL-HDBK-217D 2 dip terminals + Chip on PC board
Subtotals

Total 26 Fits

Vehicle	Strees Type	Maximum Strees	Semple Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS1990 F30	Moisture Soak	960 hr	75	n/a	0	
D/C 9304	60°C/90% Fl.H. No bias			Total	0	0.0%
DS1990 F30	Temperature Cycle	2000 ~	150	n/a	0	
D/C 9304 DS1990A F50	-40°C to +85°C, No bias			Total	0	0.0%
D/C 9317	Mechanical Shock	Gp A: 15-/axis	30	rv⁄a	0	
	Mil-Std-883C Method 2002	500g's		Total	0	0.0%
	x1, x2, y1, y2, z1, z2					
	Vibration	Cond. A	66	n/a	0	
	MILSM-883C	10 to 55 Hz		Total	0	0.0%
	Method 2005	2x.06" /axis				
R1990 R30	Storage Life	1khr	225	n/a	٥	
D/C 9108	85°C, No Blas			Total	0	0.0%
	Temperature Cycle	1000 -	150	n/a	0_	
	-40°C to +85°C, No bias			Total	0	0.0%
	Moisture Soak	480 hr	225	n/a	0	
	70°C/90% R.H. No bias			Total	0	0.0%

Fallure Mode	FA #,=	Fathure Mechanism	Ea (ev)	B (1/volt)
F1: Read type Id	None	Not Analyzed	0.7	0.43

----- TOUCH MEMORY RELIABILITY REPORT ------

Appendix II.

Notice of Qualification/Reliability Projection - DS1994L-F50 and Related

DALLAS	
SEMICONDUCTOR	

SEMICONDUCTOR									
NOTICE OF QUALIFICATION									
Date: 6/7/93									
Product Type: DS1994 LF50, DS1994 LM50 Rev B5									
Product Description: Touch Serial w/Time									
Design Type: AutoiD w/one wire port									
Component Parts: DS2404 IC, BR1225 Battery, Crystal. PC Board									
Assembly Process Description: Dallas Semiconductor, Jall-Can									
Package Type: Anode/Cathode Stainless Steel Tall Flance Can w/Polypropylene Grommet									
Reliability Process Flow Module Products Flow									
Restability Failure rate (Pits): 160 Fits									
Reliability File Nos:Q-7613. Q-8120. Q-8138. S-8287. S-8233									
The above product has successfully completed qualification on this date and									
meets Dallas Semiconductor requirement, 05-00605-000, for Fully Qualified Production Product.									
Kin Wandile July Change									
Resiability Engr. Manager Product Engr. Manager Test Engr. Manager									
Director of Manufacturing Director of Assembly Engr.									

RELIABILITY PROJECTION

DS1994LF50 / LM50 TOUCH MEMORY W/TIME

Device Types: OS1994LF50 Rev B5, OS1994LM50 Rev B5

Assembly Technology: Metal Can

Sub Components: DS2404 1/3 Wire EconoRAM, PC Board, BR1225 Battery, Crystal

Equivalent

Location: Dallas

Package Style: Anode/Cathode Tail Flange Can

Summary Data with Chi-Squared Distribution Assumed © 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

				Equivacno		
		Time	Semple	Dev. Hrs.	No. of	Fallure Rete
Sub Component	Strees	(hrs)	Size	9 55°C, 3.0V	Rejects	& Fall Mech.
DS2404B4	125°C, Dyn. 7.0V	48	784	1,33E+07	2	F1
1/3 Wire EconoRAM	, •	1000	154	5.18E+07	1	P2
	125°C, Dyn. 5.5V	1000	234	1.76E+07	0	· -
			Subtotale	8.26E+07	3	51 Fits
8R1225	Storage Life	120000		rva.	1%	
Battery	55°C		Subtotals	<u>-</u> -	1%	80
Seiko	estimate	n/a	n/a.	r/a	n/a	
Crystal			Subtotale			10
Pmtd Crkt Board	per HD8K 217D	2 dip terminals	Chip on PC t	board		
			Subtotale		·	19
Total		· · · · · · · · · · · · · · · · · · ·				160 Filte
		Meximum	Sample	Fallure	No. of	Percent
Vehicle	Stress Type	Strees	Size	Mechanism	Rejects	Rejected
DS1994LF50	Temperature Cycle	1000 ~	326	n/e	0	
DS1994LM50	-40°C to +85°C, No bias	1		Total	0	0.0%
D/C 9231, 9238, 9242, 9	240					
	Moisture Soak	960 hr	360	n/a	0	
	60°C/90% R.H. No bias			Total	0	0.0%
DS1994LF50	Storage Life	2000 hr	224	r√a. Total	0	
O/C 9207, 9206	85°C, No Bias			Total	0	0.0%
DS1991LF50	Mechanical Shock	Gp A: 18-/axis	70	n/a	0	
D/C 9123, 9131, 9136	Mif-Std-883C Method 2002	500g's		Total	0	0.0%
	x1, x2, y1, y2, z1, z2	Gp β: 18-/axis	10	n/a	0	
	,,,,	1500g/s		Total	Ŏ	0.0%
		Gp C: 18-/axis	10	n/m	0	
		3000ga		Total	Ò	0.0%
DS1991LF50	. Vibration	Cond. A	86	n/a	0	
DS1994LM50	MIII-Std-883C	10 to 55 Hz		Total	Ó	0.0%
D/C 9211, 9240	Method 2005	2x.06* /axde				
DS1994LF50	Salt Atmosphere	Cond C	10	<u>n/s.</u>	0	
DS1994LM50	Mil-S td-883	9 6 hr		Total	0	0.0%
D/C 9240, 9242	Method 1009					
Failure Mode	FA #,≘	Failure Mechan		· · · · · · · · · · · · · · · · · · ·		Es (ev) B (1/volt
F1: VccLeak /Comp	92-0104	pon gate oxide o	defect			0.3
F2: VocLeak	In Analysis					0.3

...... TOUCH MEMORY RELIABILITY REPORT

Appendix III.
MET Laboratories, Inc. - Intrinsically Safe Listing



LISTING No: DAL0913 MET PROJECT No: SAF128

DALLAS SEMICONDUCTOR
- 9RUARY 1, 1993

PRODUCT COVERED:

Touch Memories

MODELS:

DS1994, DS1993, DS1992, DS1991, DS1990

ELECTRICAL RATINGS:

MANUFACTURED BY:

DALLAS SEMICONDUCTOR 4401 S. Beltwood Pkwy Dallas, TX 75244-3292

PRODUCT DESCRIPTION:

The products covered by this report are designed to allow for storage and retrieval of information by touching the product's enclosure with a wand interface and computer approved under the entity concept and meeting the electrical ratings marked on the products. The products have been approved under the entity concept for use in CLASS I, DIVISION I, GROUPS A, B, C, and D LOCATIONS.

PREPARED BY:

MET LABORATORIES, INCORPORATED

914 W. PATAPSCO AVENUE

BALTIMORE, MARYLAND 21230

PHONE (410) 354-3300/FACSIMILE (410) 354-3313

—— TOUCH MEMORY RELIABILITY REPORT

Appendix IV.
Reliability Monitoring Results - attached

PRODUCT	MONITOR DATE _	DATE CODE	ASSEM FACIL		AFER LOT NO.	ASSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9311 B5	DALL	AS	N/A	27640	1.2 μ Ox/Ni Pas	CAN
	STRESS/JOB NO.		(Samp	READPO le Size/No	NT o. of Fails)			
	Hi Temp Storage 70°C, No Bias P-9487		0 Hr 336 H 90/0 30/0 Write Data Read D	30/0	Elect. Test 30/0 Full Elect	<u>Cum %/FA</u> 0.0%	<u>Status</u>	
	Temp Cycle 0°C to +70°C P-9489		<u>100 -</u> 30/0	500 ~ 30/0	1000 ~ 30/0	Cum %/FA 0.0%	<u>Status</u>	
	Moisture Soak 60°C/90% RH P-9488		192 F 30/0	<u>1r 576 Hr</u> 30/0	960 Hr 30/0	Cum %/FA 0.0%	<u>Status</u>	
	Package Integrity P-9481			X-Ray <u>Views</u> 5/0	Phys. <u>Dimen.</u> 5/0	FA Status N/A		

Failure Mechanism

Failure Mode

FA#

PRODUCT	MONITOR DATE _	DATE CODE	Assembl Facility	- •	AFER LOT NO.		SEMBLY OT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Ba	• •	9316 B5	DALLAS	3	N/A	24	0862AB	1.2 μ Ox/Ni Pas	F5 CAN
	STRESS/JOB NO.			EADPOI Size/No	NT . of Fails)				
	Hi Temp Storage 70°C, No Bias P-9833, P-9850		Hr 336 Hr 0/1 29/0 1	1KHr 29/0	Elect. Test 29/0	_	um %/FA .0%	Status	
		Wr	nte Data Read Data	Read Data	Full Elect				
	Temp Cycle 0°C to +70°C P-9852		<u>100 ~</u> 30/0	500 ~ 30/0	<u>1000 ~</u> 30/0		<u>um %/FA</u> .0%	<u>Status</u>	
	Moisture Soak 60°C/90% RH P-9851		192 Hr 30/0	576 Hr 30/0	960 Hr 30/0		um %/FA .0%	. Status	
	Package Integrity P-9834			X-Ray <u>Views</u> 6/0	Phys. <u>Dimen.</u> 6/0		A Status		
	Failure Mode	F	A#	Failure	Mechanism				

In Process

F1: Fail Bat Volt @ Write Engr Eval

PRODUCT	MONITOR DATE ~	DATE CODE		SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9318 B5		DALLAS	5 D	S251255AB	1.2 μ Ox/Ni Pass.	F5 CAN
			EADPOII Size/No	NT . of Fails)				
	Hi Temp Storage 70°C, No Bias P10243, P10280		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %/FA Sta</u> 0.0%	<u>itus</u>
	, 10270, 10200		Write Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P10282		100 ~ 30/0	<u>500 ~</u> 30/0	1000 ~ 30/0	Elect. Test 30/0	Cum %/FA Sta 0.0%	itus
			Read Data	Read Date	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P10281		192 Hr 30/0	<u>576 Hr</u> 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %/FA Sta</u> 0.0%	<u>itus</u>
			Read Data	Read Data	Read Data	Full Elect		
	Package Integrity P-10244				X-Ray <u>Views</u> 5/0	Phys. <u>Dimen.</u> 6/0		

FA#

Failure Mechanism

PRODUCT	MONITOR DATE _	DATE CODE		SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE		
DS1992L-F50 w/BR1225 Bat	· ·	9343 C1		DALLAS	DS:	317099AB-05	1.2 μ Ox/Ni Pass.	F5 CAN		
	STRESS/JOB NO.					READPOINT (Sample Size/No. of Fails)				
	Hi Temp Storage 70°C, No Bias P-10853, P-10867		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%			
	P-10003, P-10007		Write Data	Read Data	Read Data	Full Elect				
	Temp Cycle 0°C to +70°C P-10869		100 ~ 30/0	<u>500 ~</u> 30/0	1000 ~ 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	·		
	1 10000		Read Data	Read Data	Read Data	Full Elect				
	Moisture Soak 60°C/90% RH P-10868		192 Hr 30/0	576 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%			
			Read Data	Read Data	Read Data	Full Elect				
	Package Integrity P-10854				X-Ray <u>Views</u> 6/0	Phys. <u>Dimen.</u> 6/0				

Failure Mechanism

FA#

PRODUCT	MONITOR DATE _	DATE CODE	-	SSEMBI FACILIT	•	SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9406 C1		DALLAS	34	17079AA-25	1.2 μ Ox/Ni Pass.	F5 CAN
STRESS/JOB NO.					EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-11369		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	1 -1 1505		White Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-11371		100 ~ 30/0	<u>500 ~</u> 30/0	<u>1000 ~</u> 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	7 - 1 1 0 7 1		Read Data	Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-11370		192 Hr 30/0	<u>576 Hr</u> 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	1-11010		Read Data	Read Data	Read Data	Full Elect		
	Package Integrity P-11342				X-Ray <u>Views</u> 6/0	Phys. Dimen. 6/0		

----- Touch Memory Reliability Report ------

RELIABILITY MONITOR

PRODUCT	MONITOR DATE -	DATE CODE	-	SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE	
DS1992L-F50 w/BR1225 Bat	•	9413 C1		DALLAS	40	01055AA-23	1.2 μ Ox/Ni Pass.	F5 CAN	
	STRESS/JOB NO.				EADPOINT : Size/No. of Fails)				
	Hi Temp Storage 70°C, No Bias P-11906, P-11929		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%		
	, 1,000,1 1,020		Write Data	Read Data	Read Data	Full Elect			
	Temp Cycle 0°C to +70°C P-11931		100 ~ 30/0	<u>500 ~</u> 30/0	1000 ~ 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%		
			Read Data	Read Data	Read Data	Full Elect			
	Moisture Soak 60°C/90% RH P-11930		192 Hr 30/0	576 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%		
			Read Data	Read Data	Read Data	Full Elect			
	Package Integrity P-11905				X-Ray <u>Views</u> 6/0	Phys. Dimen. 6/0			

PRODUCT	MONITOR DATE _	DATE CODE	-	SSEMB!	,	SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9418 C1		DALLAS	5 40	05255AC-01	1.2 μ Ox/Ni Pass.	F5 CAN
	STRESS/JOB NO.			_	EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-12522, P-12608		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	1 - 12322, 1 - 12000		Write Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-12610		100 ~ 30/0	<u>500 ~</u> 30/0	1000 ~ 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
			Read Data	Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-12609		192 Hr 30/0	576 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	2000		Read Data	Read Data	Read Data	Full Elect		
	Package Integrity P-12523				X-Ray Views 6/0	Phys. Dimen. 6/0		

PRODUCT	MONITOR DATE -	DATE CODE	•	ASSEMB FACILIT		ASSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9419 D2		DALLAS	\$ 4	11557AA-23	1.2 μ Ox/Ni Pass.	F5 CAN
	STRESS/JOB NO.				EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-13210, P-13241		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	1-10210, 1-102-1		Write Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-13243		100 ∼ 30/0	<u>500 ~</u> 30/0	1000 ~ 30/1 F1	Elect. Test 30/0	<u>Cum %</u> 3.3%	
			Read Data	Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-13242		192 Hr 30/0	<u>576 Hr</u> 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
			Read Data	Read Data	Read Data	Full Elect		
	Package Integrity P-13211				X-Ray Views 6/0	Phys. Dimen. 6/0		

Failure Mode

F1: 1-RD Checkerbd

PRODUCT	MONITOR DATE _	DATE CODE	•	ASSEMB FACILIT		ASSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9427 D2		DALLAS	5 4	11562AA-23	1.2 μ Ox/Ni Pass.	F5 CAN
	STRESS/JOB NO.				EADPO	NT o. of Fails)		
	Hi Temp Storage 70°C, No Bias P-13654, P-13685		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
			Write Data	Read Date	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-13687		100 ~ 30/1 F1	<u>500 ~</u> 29/0	1000 ~ 29/0	Elect. Test 29/0	<u>Cum %</u> 3.3%	
			Read Data	Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-13686		192 Hr 30/0	<u>576 Hr</u> 30/0	960 Hr 30/0	Elect. Test 30/0	Cum % 0.0%	
			Read Data	Read Data	Read Data	Full Elect		
	Package Integrity P-13655				X-Ray <u>Views</u> 6/0	Phys. <u>Dimen.</u> 6/0		

Failure Mode

F1: 1-RD Checkerbd

PRODUCT	MONITOR DATE _	DATE CODE	•	ASSEMBI FACILIT		ASSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9433 D2		DALLAS	5 4	13096AB-09	1.2μ Ox/ N i	F5 CAN
	STRESS/JOB NO.				EADPOI	NT o. of Fails)		
	Hi Temp Storage 70°C, No Bias P-14342, P-14383		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
			Write Data	Read Data	Read Data	Full Elect		•
	Temp Cycle 0°C to +70°C P-14384			<u>300 ~</u> 30/0	1000 ~ 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-14385			288 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect	•	•
	Package Integrity P-14343				X-Ray <u>Views</u> 6/0	Phys. <u>Dimen.</u> 6/0		

PRODUCT	MONITOR DATE ~	DATE CODE	-	SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9433 D2		DALLAS	41	3096AC-23	1.2µ Ox/Ni	F5 CAN
	STRESS/JOB NO.				EADPOII Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-15017, P-15034		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	Cum % 0.0%	
	F-13017, F-13034		Wnte Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-15035			300 ~ 30/0	1000 ~ 29/1	Elect. Test 29/0 F1	Cum % 3.3%	
	1 10000			Reed Date	Reed Data	Full Cleat		
	Moisture Soak 60°C/90% RH P-15036			288 Hr 30/0	960 Hr 30/0	Elect, Test 30/0	<u>Cum %</u> 0.0%	
	1-13030			Read Data	Read Data	Full Elect		
	Package Integrity P-15018				X-Ray <u>Views</u> 6/0	Phys. <u>Dimen.</u> 6/0		

Failure Mode

F1: 1-RD Checkerbd F

PRODUCT	MONITOR DATE -	DATE		SSEMBI FACILIT	,	SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat	- -	9435 D2		DALLAS	i 41	13095 AAA 24	1.2µ Ох/Ni	F5 CAN
	STRESS/JOB NO.			-	EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-15561, P-15563		<u>0 Hr</u> 88/0	336 Hr 29/0	1KHr 29/0	Elect. Test 29/0	<u>Cum %</u> 0.0%	
			Write Data	Read Data	Read Data	Full Elect	•	•
	Temp Cycle 0°C to +70°C P-15035			300 ~ 29/0	1000 ~ 29/0	Elect. Test 29/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-15036			288 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect		

PRODUCT	MONITOR DATE -	DATE CODE	-	SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Ba		9437 D2		DALLAS	5 4 [.]	16242AA-25	1.2μ Ox/Ni	F5 CAN
	STRESS/JOB NO.				EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-15950, P-15956		<u>0 Hr</u> 90/0	336 Hr 28/0	1KHr 28/0	Elect. Test 28/0	<u>Cum %</u> 0.0%	
			Write Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-15957			300 ~ 29/0	1000 ~ 29/0	Elect. Test 29/0	<u>Cum %</u> 0.0%	
	1 13331			Read Data	Read Data	Futil Elect		
	Moisture Soak 60°C/90% RH P-15958			288 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect		

PRODUCT	MONITOR DATE -	DATE CODE		SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat	~	9535 E3		DALLAS	S 42	25882AA-02	1.2μ Ox/Ni	F5 CAN
	STRESS/JOB NO.			-	EADPOI Size/No	NT , of Fails)		
	Hi Temp Storage 70°C, No Bias P-16134, P-16386		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
			Write Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-16387			300 ~ 30/0	<u>1000 ~</u> 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
	1 - 10007			Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-16388			288 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect		

PRODUCT	MONITOR DATE	DATE CODE	. ,	ASSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9523 D2		DALLAS	45	50117AA-03	1.2µ Ох/Ni	F5 CAN
	STRESS/JOB NO.				EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-16748, P-16891		<u>0 Hr</u> 100/14 F1	336 Hr 29/0	1KHr 29/0	Elect. Test 29/0	<u>Cum %</u> 14.0%	
	Temp Cycle		Write Data	300 ~	1000 ~	Elect. Test	Cum %	
	0°C to +70°C P-16892			28/0 Read Data	28/0 Read Data	28/0 Full Elect	0.0%	
	Moisture Soak 60°C/90% RH P-16893			288 Hr 29/0	960 Hr 29/0	Elect. Test 29/0	<u>Cum %</u> 0.0%	
				Read Data	Read Data	Full Elect		

Failure Mode F1: 14-Low Battery

----- Touch Memory Reliability Report -----

RELIABILITY MONITOR

PRODUCT	MONITOR DATE -	DATE CODE		SSEMBI FACILIT		SSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS1992L-F50 w/BR1225 Bat		9611 E3		DALLAS	60	05355AB-04	1.2µ Ox/Ni	F5 CAN
	STRESS/JOB NO.				EADPOI Size/No	NT . of Fails)		
	Hi Temp Storage 70°C, No Bias P-17081, P-17089		<u>0 Hr</u> 90/0	336 Hr 30/0	1KHr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
			Write Data	Read Data	Read Data	Full Elect		
	Temp Cycle 0°C to +70°C P-17090			<u>300 ~</u> 30/0	<u>1000 ~</u> 30/0	Elect. Test 30/0	Cum % 0.0%	
	, ,,,,,,,			Read Data	Read Data	Full Elect		
	Moisture Soak 60°C/90% RH P-17091		·	288 Hr 30/0	960 Hr 30/0	Elect. Test 30/0	<u>Cum %</u> 0.0%	
				Pead Data	Pand Data	Cull Class		

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE -	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Jan-94	9352 A3	CARSEM	DM340436AW	1.2μ ΟΧ/NI	TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Burn-in 48 Hr 235/0 77/0 1KHr 77/0 *Failure Rate 77/0 77/0 31 Fits

*Chr Squared Method, 60% C. L., 55°C & 5.5V; Temperature Denating: Ea = 0.7 ev; Voltage Denating B = 1.0

Temp Cycle 100 -55°C to +125°C 76/0 P-11180

100 ~ 500 ~ 1K ~ Cum % 0.0%

24/0

Biased Moisture (HAST) 120°C/85% RH, 5.5 V. P-11179 100 Hr 77/0 Cum % 0.0%

Package Integrity X-Ray Phys. Mark. Lead
P-11112 Views Dimen. Perm. Integrity

6/0

6/0

6/0

Solderability P-11111 24/0

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE -	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Mar-94	9408 A3	CARSEM	DM346021AD	1.2µ OX/NI	TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Burn-in 48 Hr 236 Hr 77/0 77/0 *Failure Rate 231/0 77/0 77/0 30 Fits

*Chi Squared Method, 60% C. L. 55°C & 5 5V; Temperature Derating: Ea = 0.7 ev; Voltage Derating B = 1.0

Biased Moisture (HAST) 100 Hr 77/0 Cum % 0.0% P-11631

Package Integrity X-Ray Phys. Mark. Lead Solderability P-11576 Views 6/0 Dimen. 6/0 Perm. 6/0 16/0 24/0 P-11575 24/0

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE -	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	May-94	9415 A3	CARSEM	DM347073AT	1.2µ OX/NI	TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Burn-in 48 Hr 240/0 77/0 1KHr 77/0 *Failure Rate 77/0 30 Fits

*Chi Squared Method, 60% C. L., 55°C & 5.5V; Temperature Derating: Ea = 0.7 ev; Voltage Derating B = 1.0

Temp Cycle 100 ~ 500 ~ 1K ~ Cum % 77/0 77/0 77/0 0.0% P-12281

Biased Moisture (HAST) 100 Hr 77/0 Cum % 0.0% P-12280

PRODUCT	MONITOR DATE -	CODE	ASSEMBLY FACILITY	ASSEMBLY OT NO	PROCESS TYPE	PACKAGE TYPE
DS2401	Jul-94	9422 A3	CARSEM	DM409424AI	1.2µ OX/NI	TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 2336 Hr 77/0 77/0 Failure Rate 25°C, 7.0 V. 231/1 77/0 77/0 66 Fits F1

*Chi Squared Method, 60% C. L., 55*C & 5.5V; Temperature Denating: Ea = 0.7 ev, Voltage Denating B = 1.0

Temp Cycle 100 ~ 500 ~ 1K ~ Cum % 77/0 77/0 77/0 0.0% P-12851

 Biased Moisture (HAST)
 100 Hr
 Cum %

 120°C/85% RH, 5.5 V.
 73/0
 0.0%

 P-12850

Package Integrity X-Ray Phys. Mark. Lead Solderability P-12760 Dimen. 6/0 6/0 Perm. Integrity 24/0 P-12759 24/0

Failure Mode

F1: Prefunctional

PRODUCT	MONITOR DATE _	CODE .	ASSEMBLY FACILITY	ASSEMBLY OT NO	PROCESS TYPE	PACKAGE TYPE
DS2401	Sep-94	9430 A3	CARSEM	DM418322AB	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 240/0 77/0 17/0 17/0 *Failure Rate 240/0 77/0 77/0 30 Fits

*Chi Squared Method, 60% C. L., 55°C & 5.5V; Temperature Denating: Ea = 0.7 ev; Voltage Denating B = 1.0

 Package Integrity
 X-Ray Views 6/0
 Phys. Dimen. 6/0
 Mark. Lead Perm. Integrity 6/0
 Solderability P-13459 24/0

----- Touch Memory Reliability Report ------

RELIABILITY MONITOR

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE -	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Nov-94	9443 A3	CARSEM	DM429142AI	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 231/0 77/0 1KHr 77/0 *Failure Rate 201/0 77/0 77/0 30 Fits

*Chi Squared Method, 60% C. L., 55°C & 5.6V; Temperature Densing: Ea = 0.7 ev; Voltage Densing B = 1.0

Temp Cycle $\frac{300}{-55}$ °C to +125°C $\frac{300}{77/0}$ $\frac{1 \text{K}}{77/0}$ $\frac{\text{Cum }\%}{0.0\%}$ P-14066

 Biased Moisture (HAST)
 100 Hr
 Cum %

 120°C/85% RH, 5.5 V.
 77/0
 0.0%

 P-14067

 Package Integrity
 X-Ray P-14041
 Yiews 6/0
 Phys. Dimen. 6/0
 Mark. Dead Perm. Integrity 6/0
 Solderability P-14040 24/0
 P-14040 24/0

PRODUCT	MONITOR DATE _	CODE	ASSEMBLY FACILITY	ASSEMBLY OT NO	PROCESS TYPE	PACKAGE TYPE
DS2401	Jan-95	9449 A3	CARSEM	DM425668AO	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT

(Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 231/0 177/0 177/0 177/0 30 Fits
P-14581, P-14686

*Chi Squared Method, 60% C. L., 55*C & 5.5V; Temperature Denating: Ea = 0.7 ev; Voltage Denating B = 1.0

Temp Cycle 300 ~ 1K ~ Cum % 77/0 77/0 0.0% P-14687

 Biased Moisture (HAST)
 100 Hr 77/0
 Cum % 0.0%

 P-14688
 0.0%

 Package Integrity
 X-Ray P-14580
 Phys. Oimen. 6/0
 Mark. Lead Perm. Integrity 6/0
 Solderability P-14579 P-14579 P-14579 P-14579 P-14579

----- Touch Memory Reliability Report ------

RELIABILITY MONITOR

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE ~	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Mar-95	9509 B1	CARSEM	DM438816CA	1.2μ ΟΧ/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 336 Hr 1KHr 125°C, 7.0 V. 231/0 77/0 77/0 30 Fits
P-15313, P-15345

*Chi Squared Method, 60% C. L., 55°C & 5.5V; Temperature Denating; Es = 0.7 av; Voltage Denating B = 1.0

Temp Cycle $\frac{300}{77/0} \sim \frac{1 \text{K}}{77/0} \sim \frac{\text{Cum \%}}{0.0\%}$ P-15346

 Biased Moisture (HAST)
 100 Hr 77/0
 Cum % 0.0%

P-15347

Package Integrity X-Ray Phys. Phys. Lead Solderability P-15312 Views Dimen. Perm. Integrity P-15311 24/0

----- Touch Memory Reliability Report -----

RELIABILITY MONITOR

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE =	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	May-95	9518 A3	CARSEM	DM503082AW	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

 Infant / High voltage Life
 48 Hr
 336 Hr
 1KHr
 *Failure Rate

 125°C, 7.0 V.
 231/0
 77/0
 77/0
 30 Fits

 P-15739, P-15788

*Chi Squared Method, 60% C. L., 55*C & 5.5V; Temperature Denating: Ea = 0.7 ev; Voltage Denating B = 1.0

Temp Cycle 300 ~ 1K ~ Cum % 77/0 77/0 0.0% P-15789

 Biased Moisture (HAST)
 100 Hr
 Cum %

 120°C/85% RH, 5.5 V.
 77/0
 0.0%

 P-15790

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE ~	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Jul-95	9526 A3	CARSEM	DM505226AG	1.2μ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 231/0 77/0 17/0 *Failure Rate 125°C, 7.0 V. 231/0 77/0 30 Fits
P-16045, P-16097

*Chi Squared Method, 60% C. L., 55*C & 5.5V; Temperature Derating: Ea = 0.7 ev; Voltage Derating B = 1.0

Temp Cycle 300 ~ 1K ~ Cum % -55°C to +125°C 39/0 39/0 0.0% P-16098 Biased Moisture (HAST) <u>100 Hr</u> <u>Cum %</u> 120°C/85% RH, 5.5 V. 77/0 0.0% P-16099 96 Hr Autoclave Cum % 121°C/100% RH, 2 Atmos 38/1 0.0% P-16100 F1

Failure Mode

F1: 1-Prefunct.

------ Touch Memory Reliability Report -----

RELIABILITY MONITOR

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE -	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Sep-95	9535 B1	CARSEM	DM525054AF	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

Infant / High voltage Life

READPOINT (Sample Size/No. of Fails)

*Failure Rate

 $\begin{array}{ccc} \underline{48 \; Hr} & \underline{336 \; Hr} & \underline{1KHr} \\ 231/0 & 77/0 & 77/0 \end{array}$ 125°C, 7.0 V. 30 Fits P-16365, P-16405 *Chi Squared Method, 60% C, L., 55*C & 5.5V; Temperature Denating; Ea = 0.7 ev; Voltage Denating B = 1.0 Temp Cycle 300 ~ 1K~ Cum % -55°C to +125°C 38/0 38/0 0.0% P-16406 Biased Moisture (HAST) 100 Hr Cum % 120°C/85% RH, 5.5 V. 77/0 0.0% P-16407

<u>Cum %</u> Autoclave <u>96 Hr</u> 121°C/100% RH, 2 Atmos 38/0 0.0% P-16408

PRODUCT	MONITOR	DATE .	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE _	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Dec-95	9544 B1	CARSEM	DM525683AH	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life	48 Hr	336 Hr	1KHr	*Failure Rate
125°C, 7.0 V.	228/3		77/0	137 Fits
P-16740, P-16792	F1			

*Chi Squared Method, 60% C. L., 55*C & 5.5V; Temperature Derating: Ea = 0.7 ev; Voltage Derating B = 1.0

Temp Cycle -55°C to +125°C P-16793	300 ~ 36/0	<u>1K ~</u> 36/0	<u>Cum %</u> 0.0%
Biased Moisture (HAST) 120°C/85% RH, 5.5 V. P-16794		100 Hr 77/0	<u>Cum %</u> 0.0%
Autoclave 121°C/100% RH, 2 Atmos P-16795		96 Hr 38/0	Cum % 0.0%

Failure Mode

F1: 3-DQ Resistance

----- Touch Memory Reliability Report ------

RELIABILITY MONITOR

PRODUCT	MONITOR	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE	CODE	FACILITY	OT NO	TYPE	TYPE
DS2401	Mar-96	9545 B1	CARSEM	DM528323AD	1.2µ OX/NI	03 TO-92

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Infant / High voltage Life 48 Hr 336 Hr 1KHr *Failure Rate 125°C, 7.0 V. 231/0 77/0 77/0 30 Fits P-17076, P-17104

*Chi Squared Method, 60% C $_{\rm L}$, 55°C & 5.5V; Temperature Denating: Ex = 0.7 ev; Voltage Denating B \pm 1.0

Temp Cycle 300 ~ Cum % 1K~ 39/0 -55°C to +125°C 39/0 0.0% P-17105 Biased Moisture (HAST) <u>100 Hr</u> Cum % 120°C/85% RH, 5.5 V. 77/0 0.0% P-17106 Autoclave 96 Hr Cum % 121°C/100% RH, 2 Atmos 38/0 0.0% P-17107

PRODUCT	MONITOR DATE -	DATE CODE	•	ASSEMBI ACILIT			111010102	
DS2502	Nov-94	9439 A6		CARSEN	M DM41159	1AI -1.2μ ΟΧ/NI E	EPROM 08 SOIC 150	
	STRESS/JOB NO.			READPOINT (Sample Size/No. of Fails)				
	Preconditioning (P/C HTC Vapor Phase P-14021	;):			Electrical 233/0	<u>Cum %</u> 0.0%		
	Infant / High Voltage Life 48 h 125°C, 7.0 V. 230 P-14097, P-14204 F1 'Chi Squared Method, 60% C. L., 55°C & 5.5V; Ter			336 Hr 77/0	<u>1KHr</u> 77/0 : Ea ≠ 0.7 ev; Voltage De	*Failure Rate 66 Fits		
	Temp Cycle -55°C to +125°C P-14205			300 ~ 38/0	1K ~ 38/0	Cum % 0.0%		
	Biased Moisture 85°C/85% RH, 5.5 V P-14206	· -		<u>274 Hr</u> 76/0	959 Hr 76/0	Cum % 0.0%		
	Storage Life 150°C, No bias P-14207			336 Hr 37/0	1KHr 37/0	<u>Cum %</u> 0.0%		
	Package Integrity P-14019	X-Ray <u>Views</u> 6/0	Phys. <u>Dimen.</u> 6/0	Mark. Perm. 6/0	Lead Integrity 24/0	Solderability P-14002 24/0	Sonoscan, Post P/C P-14096 2/2	

2/2 F2

Failure Mode

F1: 1-Read Matrix F2: 2-Delamination

PRODUCT	MONITOR DATE ~	DATE CODE	•	ASSEMBI ACILIT			PROCESS TYPE	PACKAGE TYPE
DS2502	Jan-95 9441 A6			ANAM, K	DN415200	HAC	1.2µ OX/NI EPROM	08 SOIC 150
	STRESS/JOB NO. READPOINT (Sample Size/No. of Fails)							
	Preconditioning (P/O HTC Vapor Phase P-14021)):			Electrical 233/0	Cum % 0.0%	2	
	Infant / High Voltage 125°C, 7.0 V. P-14710, P-14766		48 Hr 231/0	336 Hr 77/0	1KHr 77/0	*Failure 30 Fits		
	*Chi Squared Method, 60% C. L., 55*C & 5.5V; Temperature Derating: Ea = 0.7 ev; Voltage Derating B = 1.0							
	Temp Cycle -55°C to +125°C P-14767			300 ~ 39/0	1K ~ 39/0	<u>Cum %</u> 0.0%	<u> </u>	
	Biased Moisture 85*C/85% RH, 5.5 V P-14768	/ .	,	274 Hr 77/0	959 Hr 77/0	Cum % 0.0%	2	
	Storage Life 150°C, No bias P-14769			336 Hr 36/0	1KHr 36/0	Cum % 0.0%	2	
	Package Integrity P-14585	X-Ray <u>Views</u> 6/0	Phys. Dimen 6/0		Lead Integrity 24/0	Soldera P-1458 24/0		

RELIABILITY MONITOR

PRODUCT	MONITOR DATE _	DATE CODE	. ,	ASSEMBL ACILITY			PROCESS TYPE	PACKAGE TYPE
DS2502	Mar-95	9507 A6		ANAM, K	DN434372	AIA	1.2µ OX/NI EPROM	08 SOIC 150
	STRESS/JOB NO.				EADPOINT Size/No. of Fail	s)	2, , , , , , ,	
	Preconditioning (P/C HTC Vapor Phase P-15427):			Electrical 233/0	Cum % 0.0%	<u>′o</u>	
	Infant / High Voltage 125°C, 7.0 V. P-15484, P-15521	2	18 Hr 230/0	336 Hr 77/0	1KHr 77/0	30 Fits		
	*Chi Squared Method, 60% C.	L . 55"C & 5.5V	: Temper	alure Derating	: Ea = 0.7 ev; Voltage De	erating B = 1	C	
	Temp Cycle -55°C to +125°C P-15522			300 ~ 38/0	1 <u>K ~</u> 38/0	<u>Cum %</u> 0.0%	<u>′o</u>	
	Biased Moisture 85*C/85% RH, 5.5 V P-15523	-		<u>274 Hr</u> 64/0	959 Hr 64/0	Cum % 0.0%	<u>6</u>	
	Storage Life 150°C, No bias P-15524			336 Hr 38/0	1KHr 38/0	Cum % 0.0%	<u>6</u>	
	Package Integrity P-15425	•	Phys. Dimen.	Mark. Perm.	Lead Integrity	Solder P-1542		

Failure Mode

RELIABILITY MONITOR

PRODUCT	MONITOR _	DATE	ASSEMBLY	ASSEMBLY	PROCESS	PACKAGE
	DATE	CODE	ACILITY	LOT NO	TYPE	TYPE
DS2502	May-95	9512 A6	CARSEM	DM436518ACA	1.2µ OX/NI EPROM	08 SOIC 150

STRESS/JOB NO.

READPOINT (Sample Size/No. of Fails)

Preconditioning (P/C): Electrical Cum % HTC Vapor Phase 233/0 0.0% P-15762

Infant / High Voltage Life *Failure Rate 1KHr 125°C, 7.0 V. 30 Fits

P-15802, P-15838

*Chi Squared Method, 60% C | L., 55*C & 5.5V; Temperature Derating, Ea = 0.7 ev; Voltage Derating B \pm 1.0

300 ~ 39/0 Temp Cycle <u>1K ~</u> Cum % -55°C to +125°C 39/0 0.0% P-15839

Biased Moisture <u> 274 Hr</u> 959 Hr Cum % 85°C/85% RH, 5.5 V. Note: Not performed due to board capacity P-15840

Storage Life 150°C, No bias P-15841 336 Hr 38/0 Cum % 1KHr 38/0 0.0%

Failure Mode

RELIABILITY MONITOR

PRODUCT	MONITOR DATE ~	DATE CODE	ASSEMBLY ACILITY	ASSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS2502	Jul-95	9509 A6	CARSEM	DM434371AHA	1.2µ OX/NI	08 SOIC 150
;	STRESS/JOB NO.			OPOINT	EPROM	

(Sample Size/No. of Fails)

Preconditioning (P/C): HTC Vapor Phase P-16030			Electrical 233/0	<u>Cum %</u> 0.0%
Infant / High Voltage Life 125°C, 7.0 V. P-16067, P-16101 *Chi Squared Method, 60% C. L., 55°C & 5	48 Hr 231/0	336 Hr 77/0	1KHr 77/0	*Failure Rate 30 Fits
			, and the state of	
Temp Cycle -55°C to +125°C P-16102		300 ~ 39/0	1K ~ 39/0	<u>Cum %</u> 0.0%
Biased Moisture 85°C/85% RH, 5.5 V. P-16103		274 Hr 77/0	959 Hr 77/0	<u>Cum %</u> 0.0%
Storage Life 150°C, No bias P-16104		336 Hr 38/0	1KHr 38/0	<u>Cum %</u> 0.0%

Failure Mode

RELIABILITY MONITOR

PRODUCT	MONITOR DATE _	DATE CODE	ASSEMBLY ACILITY	ASSEMBLY LOT NO	PROCESS TYPE	PACKAGE TYPE
DS2502	Sep-95	9516 A6	CARSEM	DM440165GAA	1.2µ OX/NI EPROM	08 SOIC 150

STRESS/JOB NO.

READPOINT

Office deliver in the control of the			Size/No. of Fails	3)
Preconditioning (P/C): HTC Vapor Phase P-16363			Electrical 232/0	<u>Cum %</u> 0.0%
Infant / High Voltage Life 125°C, 7.0 V. P-16379, P-16399 *Chi Squared Method, 60% C. L., 55°C & 5	48 Hr 230/2 F1,F2 5V; Tempe	336 Hr 77/0 rature Derating	1KHr 77/0 : Ea = 0.7 ev: Voltage De	*Failure Rate 102 Fits
Temp Cycle -55°C to +125°C P-16400		300 ~ 39/0	<u>1K ~</u> 39/0	Cum % 0.0%
Biased Moisture 85°C/85% RH, 5.5 V. P-16401		274 Hr 77/0	959 Hr 77/0	<u>Cum %</u> 0.0%
Storage Life 150°C, No bias P-16402		336 Hr 35/0	1KHr 35/0	<u>Cum %</u> 0.0%

Failure Mode

F1: 1-lol/Vol F2: 1-Read Matrix

RELIABILITY MONITOR

PRODUCT	MONITOR DATE -	DATE CODE		ASSEMBL ACILITY			PROCESS TYPE	PACKAGE TYPE
DS2502	Dec-95	9546 A6		CARSEM	DM534661A	ANA	1.2µ OX/NI EPROM	08 SOIC 150
	STRESS/JOB NO.				EADPOINT Size/No. of Fails	s)		
	Preconditioning (P/ HTC Vapor Phase P-16744	C) :			Electrical 233/0	<u>Cum %</u> 0.0%	<u>6</u>	
	Infant / High Voltag 125°C, 7.0 V. P-16774, P-16894 *Chi Squared Method, 60%		48 Hr 231/0 V: Temper	336 Hr 77/0	1KHr 77/1 F1 : Ea = 0.7 ev: Voltage De	67 Fits		
	Temp Cycle -55°C to +125°C P-16895			300 ~ 39/0	1K~ 39/0	Cum % 0.0%	<u>6</u>	
	Biased Moisture 85*C/85% RH, 5.5 P-16896	V.		274 Hr 77/0	959 Hr 77/1 F2	<u>Cum %</u> 1.3%	<u>%</u>	
	Storage Life 150°C, No bias P-16897			336 Hr 38/0	1KHr 38/0	Cum 9 0.0%	<u>6</u>	

Failure Mode

F1: Read Matrix F2: DQ Resistance

RELIABILITY MONITOR

PRODUCT	MONITOR DATE	DATE CODE		ASSEMBI ACILIT		•	PROCESS TYPE	PACKAGE TYPE
DS2502	Mar-96	9546 A6		CARSEN	M DM534656	BATA	1.2µ OX/NI EPROM	08 SOIC 150
	STRESS/JOB NO.				EADPOINT Size/No. of Fai	ls)	El Koli	
	Preconditioning (P/HTC Vapor Phase P-17086	C):			Electrical 229/1 F1	<u>Cum 9</u> 0.4%	<u>//o</u>	
	Infant / High Voltag 125°C, 7.0 V. P-17098, P-17138 *Chi Squared Method, 60% (ļ	48 Hr 226/1 F2	336 Hr 70/0	1KHr 70/0	72 Fits	_	
	Temp Cycle	J. E., 55 G G G 5.5	v. 1011pc					
	-55°C to +125°C P-17139			300 ~ 38/0	1K ~ 38/0	<u>Cum 9</u> 0.0%	<u>⁄6</u>	
	Biased Moisture 85°C/85% RH, 5.5 N P-17140	V. .		<u>274 Hr</u> 74/0	959 Hr	Cum 9	<u>//•</u>	
	Storage Life 150°C, No bias P-17141			336 Hr 37/0	1KHr 37/0	<u>Cum %</u> 0.0%	<u>/a</u>	

Failure Mode

F1: Preset Matrix F2: DQ Resistance

----- TOUCH MEMORY RELIABILITY REPORT -----

Appendix V. Example FIT Rate Calculation

The data presented in the Notice of Qualification provided by the Dallas Semiconductor Quality and Reliability Department expresses the reliability failure rate in FITs. A FIT is a a figure of merit that predicts the statistical likelihood of failure within a certain population of parts e er a given period of time. A FIT is equal to 1 failure in 1 billion cumulative device hours. The determination of this figure is usually achieved thru accelerated testing that is then extrapolated back to the actual use conditions. This is necessary to be able to achieve qualication of a product within a reasonable period (i.e. cannot wait for 10 years to determine that 10 year data retention is possible).

An example using the information provided in Appendix I. shows how the number of FITs for a device can predict the number of failures in a given application.

Assumptions:

- 1) Device type is DS1990A-F30; reliability failure rate is 26 FITs (Appendix I.)
- 2) Use condition is within datasheet specification
- 3) Application requires the use of 100,000 units

For 100K units:

26 FITs = 26 failures per 1 billion device hours

26 failures per 1 billion device hours/100K devices = 26 failures per 10K hours

10K hours is approximately 1.2 years

With a FIT rate of 26, out of the original 100K units the cumulative number of failures would be 217 (.2%) over a 10 year period.

..... TOUCH MEMORY RELIABILITY REPORT -----

Appendix VI.

Maximum Number of Transactions and Lifetime Calculations for Touch Memory

In this section two different lifetime calculations for Touch Memories are presented:

- a) maximum possible number of transactions during the service life of 10 years before the available energy is consumed
- b) lifetime of the internal energy source if tran actions occur such that a device is constantly accessed at the maximum possible rate

For each calculation a typical and a worst case is considered. D\$1991/22 are very similar with respect to energy consumption. The transaction cycle for the D\$1991 is 8 bits shorter than for the other devices. Since this is only a minor difference, the values of the D\$1992/3 are also used for the D\$1991. The D\$1994 needs to be considered separately, since the timekeeping circuitry causes a standby current (no communication occurring) which is higher than the standby current of the other devices.

I. Definition of a transaction

One transaction consists of the following steps:

A. Initialization (Reset and Presence)	960µs
B. ROM Function Command (Skip ROM)	488µs (61µs x 8)
C. Memory Function Command (Write Scratch)	488µs (61µs x 8)
D. Target Address (write 16 bits)	976µs (61µs x 16)
E. Data (write 256 bits)	15,616µs (61µs x 256)
F. Initialization (Reset and Presence)	960µs
G. ROM Function Command (Skip ROM)	488µs (61µs x 8)
H. Memory Function Command (Read Scratch)	488µs (61µs x 8)
I. Target Address (read 24 bits)	1464µs (61µs x 24)
J. Data (read 256 bits)	15,616µs (61µs x 256)
Minimum time for one transmiss 27 544	13,010µ8 (01µ8 X 230)

Minimum time for one transaction: 37.544 ms.

II. Lithium Cell and Device Data

Capacity of BR1225:

Qbat = 35mAh => 35mAh/(24h/day * 365.25day/yr) = 3.99µAyr

A. Device Data, typical case:

Standby Current DS1991/2/3: IBAT1 = 25nA

DS1994: IBAT1 = 200nA

Operating Charge: DS1991/2/3/4 QBAT0 = 100nC/trans

B. Device Data, worst case: (from 1992/3 databook):

Standby Current DS1991/2/3: IBAT1 = 200nA

DS1994: IBAT1 = 350nA

Operating Charge: DS1991/2/3/4 QBAT0 = 200nC/trans

----- TOUCH MEMORY RELIABILITY REPORT -----

III. Expected number of available transactions:

During the Service Life of 10 years the charge consumed in the standby mode is:

$$QSTB = IBAT1 * 10yr$$

A. typical case:

DS1991/2/3: QSTB = $25nA * 10yr = 0.25 \mu Ayr$ DS1994: QSTB = $200nA * 10yr = 2.00 \mu Ayr$

B. worst case:

DS1991/2/3: QSTB = $200nA * 10yr = 2.00 \mu Ayr$ DS1994: QSTB = $350nA * 10yr = 3.50 \mu Ayr$

With the lithium cell of Qbat = 3.99 μ Ayr, the charge available for transactions is: Qavail = Obat - OSTB

A. typical case:

DS1991/2/3: Qavail = 3.99μ Ayr - 0.25μ Ayr = 3.74μ Ayr DS1994: Qavail = 3.99μ Ayr - 2.00μ Ayr = 1.99uAyr

B. worst case:

DS1991/2/3: Qavail = 3.99μ Ayr - 2.00μ Ayr = 1.99μ Ayr DS1994: Qavail = 3.99μ Ayr - 3.50μ Ayr = 0.49μ Ayr

Since one year is 31.56 million seconds, 1 µAyr is equivalent to 31.56 Coulombs.

The number of available transactions is:

TRavail = Qavail / QBATO

A. typical case:

DS1991/2/3: TRavail = 3.74 * 31.56 C / 100nC = 1180 millionDS1994: TRavail = 1.99 * 31.56 C / 100nC = 628 million

B. worst case:

DS1991/2/3: TRavail = 1.99*31.56 C / 200nC = 314 millionDS1994: TRavail = 0.49*31.56 C / 200nC = 77.3 million

IV. Expected lifetime when transactions occur at maximum 1-wire rate:

Since one transaction takes minimum 37.544ms the maximum rate of transactions is TRrate = 1 / 37.544ms = 26.6 transactions / s

The current drained from the lithium cell at the maximum rate of transactions is:

Imaxtr = QBAT0 * TRrate + IBAT1

----- TOUCH MEMORY RELIABILITY REPORT -----

A. typical case:

DS1991/2/3:

 $Imaxtr = 100nC * 26.6/s + 25nA = 2.685 \mu A$

DS 1994:

 $Imaxtr = 100nC * 26.6/s + 200nA = 2.860 \mu A$

B. worst case:

DS1991/2/3:

 $Imaxtr = 200nC * 26.6/s + 200nA = 5.520 \mu A$

DS1994:

Imaxtr = $200nC * 26.6/s + 350nA = 5.670 \mu A$

With the total charge of the lithium cell being 3.99 μ Ay₁, the calcust lifetime of the device is:

Lifetime = Capacity / Imaxtr

A. typical case:

DS1991/2/3:

Lifetime = $3.99 \,\mu \text{Ayr} / 2.685 \,\mu \text{A} = 1.486 \,\text{yr}$

DS1994:

Lifetime = $3.99 \,\mu\text{Ayr} / 2.860 \,\mu\text{A} = 1.395 \,\text{yr}$

B. worst case:

DS1991/2/3:

Lifetime = $3.99 \,\mu \text{Ayr} / 5.520 \,\mu \text{A} = 0.723 \,\text{yr}$

DS1994:

Lifetime = $3.99 \, \mu \text{Ayr} / 5.670 \, \mu \text{A} = 0.704 \, \text{yr}$

During this calculated lifetime the number of transactions is:

NRtr = Lifetime * TRrate

A. typical case:

DS1991/2/3:

NRtr = 1.486 yr*31.56 million s/yr*26.6/s = 1247 million

DS1994:

NRtr = 1.395 yr + 31.56 million s/yr + 26.6/s = 1171 million

B. worst case:

DS1991/2/3:

NRtr = 0.723 yr * 31.56 million s/yr * 26.6/s = 607 million

DS1994:

NRtr = 0.704 yr * 31.56 million s/yr * 26.6/s = 591 million

—— TOUCH MEMORY RELIABILITY REPORT ——

Appendix VII.

Additional Product Reliability Projections - attached

RELIABILITY PROJECTION DS1205S

Product Types:

DS1205 REV: B2, B4

Date Codes:

9122, 9127, 9128

Process Technology:

Si Gate CMOS

Channel Length: 1.2 µ

Metal Pitch: 3.0µ

Assembly Technology

Site. ANAM

Package: 16 SOIC

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea = 0.7 ev, B = 1.0 Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

			Equivalent		
Stress	Time (hrs)	Sample Size	Dev. Hrs. @ 55°C, 5.5V	No. of Rejects	Failure Rate & Fail Mech.
125°C, Dyn. 7.0V	36	1050	1.3E+07	1	F1
	1000	231	7.7E+07	0	
125°C, Dyn. 5.5V	1000	348	2.6E+07	0	
Totals			1.17E+08	1	17 Fits

Package Tests

Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
Temperature Cycle -55°C to +125°C	1000 -	231	n/a	0	
			Total	0	0.0%
Temperature Humidity 85°C/85% R H , 5 5V	959 hr	231	F2, F3	2	
			Total	2	0.9%

Failure M	lechanism	Corrective Action
F1	IccStby	Pending, Product Engr Evaluation
F2	Continuity	Pending, Product Engr Evaluation
F3	Functional	Pending, Product Engr Evaluation

RELIABILITY PROJECTION DS1420 F30

TOUCH MEMORY CHIP

Assembly Technology: Metal-Can

Sub Components: DS915 Touch Memory Chip, PC Board

Location: Dallas

Package Style: Anode/Cathode Short (F30) & Can w/Flange & Polypropylene Grommet

No. Pins: 0

Summary Data with Chi-Squared Distribution Assumed for IC's and Ea & B as noted below Stress Ambient Temperature & Voltage to Field Ambient Temperature & Voltage

		Time	Sample	Equivalent Dev. Hrs.	No. of	Failure Rate
Sub Component	Stress	(hrs)	Size	@ 55°C	Rejects	& Fail Mech.
DS914 A1	125°C, 7.0 V, Dyn.	48	1394	2.33E+07	1	F1
Touch Mem Chip		96	898	1.50E+07	0	
D/C 9045, 9049, 910	7	1000	444	1.47E+08	0	
	125°C, 5.5 V, Dyn	1000	444	3.27E+07	0	
DS914 A2	125°C, 7.0 V, Dyn.	504	196	3.43E+07	0	
D/C 9143	•					
DS915 A2	125°C, 7.0 V, Dyn.	72	490	1.23E+07	0	
D/C 9308		1072	77	2.68E+07	0	
Subtotals	,			2.9E+08	1	7 Fits
Prnt'd Crkt Board	per MIL-HOBK-217D	2 clip termi	nals + Chip on PC	board		
Subtotals						19
				Total		26 Fits

				Total		26 Fits
Vehicle		Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS1990 F30	Moisture Soak	960 hr	75	n/a	0	
D/C 9304	60°C/90% R.H. No bias			Total	0	0.0%
DS1990 F30	Temperature Cycle	2000 ~	150	n/a	0 -	
D/C 9304 DS1990A F50	-40°C to +85°C. No bias	•		Total	0	0.0%
D/C 9317	Mechanical Shock	Gp A: 18~/axis	30	n/a	0	
	Mil-Std-883C Method 2002 x1, x2, y1, y2, z1, z2	500g's		Total	0	0.0%
	Vibration	Cond. A	66	n/a	0	
	Mil-Std-883C Method 2005	10 to 55 Hz 2x.06" /axis		Total	0	0.0%
R1990 R30	Storage Life	1khr	225	n/a	0	
D/C 9108	85°C, No Bias			Total	0	0.0%
	Temperature Cycle	1000 ~	150	n/a	0	
	-40°C to +85°C, No bias	i		Total	0	0.0%
	Moisture Soak	480 hr	225	n/a	0	
	70°C/90% R.H. No bias			Total	0	0.0%

Failure Mode	FA# _i s	Failure Mechanism	Ea (ev)	B (1/volt)
F1: Read type Id	None	Not Analyzed	0,7	0.43

RELIABILITY PROJECTION . DS1425LF5 Rev C1 Touch MultiKey

Device Types: DS1425LF50 Rev C1

Assembly Technology: Metal Can

Sub Components: DS1205 MultiKey, PC Board, 8R1225 Battery

Location: Dallas

Package Style: Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed for IC's and Ea = 0.7 ev Stress Ambient Temperature to Field Ambient Temperature o Voltage Derating

Sub Component	Stress	Time (hrs)	Sample Size	Equivalent Dev. Hrs. @ 55°C	No. of Rejects	Failure Rate & Fail Mech.
DS1205S	125°C, Dyn. 7.0V	36	1050	1.31E+07	1	F1
Multi Key		1000	231	7.74E+07	0	
	125°C, Dyn. 5.5V	1000	348	2.60E+07	0	
			Subtotals	1.17E+08	1	17 Fits
BR1225	Storage Life	120000		. n/a	1%	
Battery	55°C		Subtotals		1%	80
Prnt'd Crkt Board	er MIL-HDBK-217D	2 clip termina	als + Chip on PC	board		
			Subtotals			19
				Total		116 Fits

Package Tests

Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS1991F5 Rev C1	Temperature Cycle	1000 ~	225	n/a	0	-
	-40°C to +85°C, No bias	S		Total	0	0.0%
	Moisture Soak	2000 hr	225	n/a	0	
	70°C/90% R.H. No bias	i		Total	0	0.0%
	Storage Life	2000 hr	224	n/a	0	
	85°C, No Bias			Total	0	0.0%
DS1991F5 Rev B1	Mechanical Shock	Gp A: 18~/axis 70	70	n/a	0	
	Mil-Std-883C Method 2002	500g's		Total	0	0.0%
	x1, x2, y1, y2, z1, z2	Gp B: 18~/axis	10	n/a	0	
		1500g's		Total	0	0.0%
		Gp C: 18~/axis	10	n/a	0	
		3000g's		Total	0	0.0%

Failure Mode	FA#,s	Failure Mechanism	Ea (ev)	B (1/volt)
F1: ICC	None	Not Analysed	0.7	0.43

RELIABILITY PROJECTION DS1427LF50 / LM50

Touch 4K X 1 Memory w/Time

Device Types: DS1427LF50 Rev B5, DS1427LM50 Rev B5

Assembly Technology: Metal Can

Sub Components: DS2404 1/3 Wire EconoRAM, PC Board, BR1225 Battery, Crystal

Package Style: Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B'as assigned below Stress Ambient Temperature and Voltage to

Field Ambient Temperature and Voltage

				Equivalent			
Section Comments	•	Time	Sample	Dev. Hrs.	No. of		ure Rate
Sub Component DS2404B4	Stress	(hrs) 48	Size 784	@ 55°C, 3.0V	Rejects		ail Mech.
1/3 Wire EconoRAM	125°C, Dyn. 7.0V	1000	784 154	1.33E+07 5.18E+07	2	F1	
THE PARTY CONTOURNAME	125°C, Dyn. 5.5V	1000	234	1.76E+07	1 0	F2	
	720 0, 07 0.01	, 555	Subtotals	8.26E+07	3		51 Fits
					•		011103
BR1225	Storage Life	120000		n/a	1%		
Battery	55°C		Subtotals		1%		80
Seiko	estimate	n/a	n/a	n/a	n/a		
Crystal			Subtotals		194		10
Prnt'd Crkt Board	per HDBK 217D	2 clip terminals		board			
			Subtotals				19
Total			· · · · · · · · · · · · · · · · · · ·				150 Fits
							IDO FILS
		Maximum	Sample	Failure	No. of	Per	cent
Vehicle	Stress Type	Stress	Size	Mechanism	Rejects	Re	ected
DS1994LF50	Temperature Cycle	1000 ~	328	n/a	0		
DS1994LM50	-40°C to +85°C, No bias	i		Total	0		0.0%
D/C 9231, 9238, 9242, 92							
	Moisture Soak	960 hr	360	n/a	0		
	60°C/90% R.H. No bias			Total	0		0.0%
OS1994LF50	Storage Life	2000 hr	224	ηίa	0		•
D/C 9207, 9208	85°C, No Bias	_	-	Total	ō		0.0%
554554 554							
DS1991LF50	Mechanical Shock	Gp A: 18~/axis	70	n/a	0		
D/C 9123, 9131, 9136	Mil-Std-883C Method 2002	500g's		Total	0		0.0%
	x1, x2, y1, y2, z1, z2	Gp B: 18~/axis	10	n/a	0		
		1500g's		Total	0		0.0%
		0-0-10-1			_		
		Gp C: 18-/axis 3000g's	10	n/a Total	0		
		3000g s		TOTAL	U		0.0%
DS1991LF50	Vibration	Cond. A	66	n/a	O		
DS1994LM50	Mil-Std-883C	10 to 55 Hz		Total	0		0.0%
D/C 9211, 9240	Method 2005	2x.06" /axis					
DS1994LF50	Salt Atmosphere	Cond C	10	n/a	0		
DS1994LM50	Mil-Std-883	96 hr	10	Total	0		0.0%
D/C 9240, 9242	Method 1009	UU 111		, otal	J		U.U /6
Failure Mode F1: VccLeak	FA #,s	Failure Mechan				Ea (ev)	B (1/volt)
/Comp	92-0104	pch gate oxide d	eiect			0.3	1
F2: VccLeak	In Analysis					0.3	1
/Comp/True	· · · · · · · · · · · · · · · · · · ·					0.5	1

RELIABILITY PROJECTION DS1494LF50 / LM50

- Touch 4K X 1 Memory w/Time

Device Types: DS1494LF50 Rev B5, DS1494LM50 Rev B5

Assembly Technology: Metal Can

Sub Components: DS2404 1/3 Wire EconoRAM, PC Board, BR1225 Battery, Crystal

Location: Dallas

Package Style: Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

				Equivalent		
		Time	Sample	Dev. Hrs.	No. of	Failure Rate
Sub Component	Stress	(hrs)	Size	@ 55°C, 3.0V	Rejects	& Fail Mech.
US2404B4	125°C, Dyn 7.0V	48	784	1.33E+07	2	FI
1/3 Wire EconoRAM		1000	154	5.18E+07	1	F2
	125°C, Dyn. 5.5V	1000	234	1.76E+07	0	
			Subtotals	8.26E+07	3	51 Fits
BR1225	Storage Life	120000		n/a	1%	
Battery	55*C		Subtotals	- · · · · · · · · · · · · · · · · · · ·	1%	80
Seiko	estimate	n/a	n/a	n/a	n/a	
Crystal			Subtotals			10
Prnt'd Crkt Soard	per HDBK 2170	2 clip terminals	+ Chip on PC	board		
			Subtotals			19
Total						160 Fits
		Maximum	Sample	Failure	Ma. ad	B4
Vehicle	Stress Type	Stress	Size	Fallure Mechanism	No. of Rejects	Percent Rejected
DS1994LF50	Temperature Cycle	1000 ~	328	n/a	0	
DS1994LM50	-40°C to +85°C, No bis	as		Total	0	0.0%
D/C 9231, 9238, 9242, 92						
•	Moisture Soak	960 hr	360	n/a	0	
	60°C/90% R.H. No bia	is		Total	0	0.0%
DS1994LF50	Storage Life	2000 hr	224	n/a	0	
D/C 9207, 9208	85°C, No Bias			Total	0	0.0%
OS1991LF50	Mechanical Shock	Gp A; 18~/axis	70	n/a	С	
D/C 9123 9131, 9136	Mil-Std-883C	500g's		Total	ō	0.0%
•	Method 2002			,,	•	
	x1 x2, y1, y2, z1, z2	Gp B. 18~/axis	10	n/a	0	
		1500g's		Total	0	0.0%
		Gp C: 18-/axis	10	r/a	Đ	
		3000g's		Total	0	0.0%
DS1991LF50	Vibration	Cond. A	66	n/a	0	
DS1994LM50	Mil-Std-883C	10 to 55 Hz	••	Total	Ö	0.0%
D/C 9211, 9240	Method 2005	2x.06" /axis				·-
DS1994LF50	Salt Atmosphere	Cond C	10	n/a	0	
DS1994LM50	Mil-Std-883	96 hr		Total	0	0.0%
D/C 9240 9242	Method 1009					•
Failure Mode	FA #,s	Failure Mechai	nism		Ea ((ev) B (1/volt)
F1 VccLeak	92-0104	pch gate oxide	defect			03 1
/Comp						
F2 VccLeak	in Analysis					03 1
/Comp/True						

RELIABILITY PROJECTION DS1982 F30/50

Device types: DS1982 F30/50

Assembly Technology: Metal Can

Sub Components: DS2502 Touch Memory w/ 1K EPROM Chip, PC Board

Equivalent

Location: Dallas

Package Style: Anode/Cathode Short (F30) & Tall (F50) Can w/Flange & Polypropylene Grommet

Summary Data with Chi-Squared Distribution Assumed
Stress Ambient Temperature and Voltage (125°C, 5.5V, 6.0V or 7.0V)
to Field Ambient Temperature and Voltage (55°C, 5.5V)
Voltage and Temperature Acceleration as noted below

Sub Component	Stress	Time (hrs)	Sample Size	Dev. Hrs. @ 55°C, 5.50 V	No. of Rejects	Fallure Rate & Fall Mech.
DS2502 A6		48 1000	692 231	1.15E+07 8.03E+07	0	
D/C 9507, 9509, 951 Subtotals	4	1000	231	9.2E+07	0	10 Fit
30000012				3.22.77		10 110
Prnt'd Crkt Board	per MIL-HDBK-217D	2 clip terminals	+ Chip on P	C board		
Subtotals						19
				Total	 	29 Fit
Vehicle	Stress Type	Maximum Stress	Sample Size	Fallure Mechanism	No. of Rejects	Percent Rejected
OS1990 F30	Moisture Soak	960 hr	75	n/a	0	
D/C 9304	60°C/90% R.H. No bid	as		Total	0	0.0%
DS1990 F30	Temperature Cycle	2000 ~	150	n/a	0	
D/C 9304 DS1990A F50	-40°C to +85°C, No b	ias		Total	0	0.0%
D/C 9317	Mechanical Shock	Gp A: 18~/axis	30	n/a	0	
	Mil-Std-883C Method 2002 x1, x2, y1, y2, z1, z2	500g's		Total	0	0.0%
	Vibration	Cond. A	66	n/a	0	
	Mil-Std-883C Method 2005	10 to 55 Hz 2x.06" /axis		Total	0	0.0%
R 1990 R30	Storage Life	1khr	225	n/a	0	
D/C 9108	85°C No Bias			Total	0	0.0%
	Temperature Cycle	1000 ~	150	n/a	0	
	-40°C to +85°C, No b	ias		Total	0	0.0%
	Moisture Soak	480 hr	225	n/a	0	
	70°C/90% R.H. No bi	as		Total	0	0.0%
Failure Mode	FA	\ #,s	Failure Me	echanism	Ea (ev)	B (1/voit)
None	n/a		n/a		0.7	1

RELIABILITY PROJECTION DS1990

TOUCH SERIAL NO.

Device Types: DS1990A

Assembly Technology: Metal Can

Sub Components: DS914 Touch Memory Chip, PC Board

Location: Dallas Package Style: Anode/Cathode Can

Summary Data with Chi-Squared Distribution Assumed for IC's and Ea = 0.7 ev Stress Ambient Temperature to Field Ambient Temperature No Voltage Derating

	Equivalent							
Sub Component	Stress	Time (hrs)	Sample Size	Dev. Hrs. @ 55°C	No. of Rejects	Failure Rate & Fail Mech.		
DS914	125°C, 7.0 V, Dyn.	48	898	3.34E+06	1	F1		
Memory Chip	125°C, 7.0 V, Dyn.	1000	444	3.27E+07	0			
	125°C, 5.5 V, Dyn	1000	444	3.27E+07	٥			
Subtotals				6.9E+07	1	9 Fit		

Prnt'd Crkt Board per MIL-HDBK-217D	2 clip terminals + Chip on PC board	
Subtotals		19
	Total	28 Fits

Package Tests

Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
Temperature Cycle -40°C to +85°C. No bias	1000 ~	150	n/a Total	0	0.0%
Moisture Soak	480 hr	225	n/a	0	
70°C/90% R.H. No bias			Total	0	0.0%
Storage Life	1khr	225	n/a	0	
85°C, No Bias			Total	0	0.0%

Failure Mechanism		Corrective Action
F1	Read Type Id	None

RELIABILITY PROJECTION . DS1991LF5 Rev C1 OUCH SERIAL NO.

Device Types: DS1991LF5

Assembly Technology: Metal Can

Sub Components: DS1205 MultiKey, PC Board, BR1225 Battery

Location: Dallas

Package Style: Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed for IC's and Ea = 0.7 ev Stress Ambient Temperature to Field Ambient Temperature o Voltage Derating

Sub Component	Stress	Time (hrs)	Sample Size	Equivalent Dev. Hrs. @ 55°C	No. of Rejects	Failure Rate & Fail Mech.
DS:1058	125°C, Dyn. 7.0V	36	1050	1.31E+07	1	F1
Multi Key		1000	231	7.74E+07	0	
	125°C, Dyn. 5.5V	1000	348	2.60E+07	0	
			Subtotals	1.17E+08	1	17 Fits
BR1225	Storage Life	120000		n/a	1%	
Battery	55°C		Subtotals		1%	80
Prnt'd Crkt Board	per MIL-HDBK-217D	2 clip termin	als + Chip on PC	board		
			Subtotals			19

Total 116 Fits

Package Tests

Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS1991F5 Rev C1	Temperature Cycle	1000 ~	225	n/a	0	
	-40°C to +85°C, No bia	as		Total	0	0.0%
	Moisture Soak	2000 hr	225	n/a	0	
	70°C/90% R.H. No bia	s		Total	0	0.0%
	Storage Life	2000 hr	224	n/a	0	
	85*C, No Bias			Total	0	0.0%
DS1991F5 Rev B1	Mechanical Shock	Gp A: 18~/axis	70	n/a	0	
	Mil-Std-883C Method 2002	500g's		Total	0	0.0%
	x1, x2, y1, y2, z1, z2	Gp B: 18~/axis	10	n/a	0	
		1500g's		Total	0	0.0%
		Gp C: 18~/axis	10	n/a	0	
		3000gʻs		Total	0	0.0%

Failure Mode	FA #,s	Failure Mechanism	Ea (ev)	B (1/volt)
F1: ICC	None	Not Analysed	0.7	0.43

RELIABILITY PROJECTION DS1991S-R30

Device Types: DS1991S-R30

Assembly Technology: Metal Can

Sub Components: DS1205 MultiKey, PC Board, BR1225 Battery

Location: Dallas

Package Style: Anode/Cathode Short Can

Summary Data with Chi-Squared Distribution Assumed for IC's and Ea = 0.7 ev Stress Ambient Temperature to Field Ambient Temperature o Voltage Derating

				Equivalent		
Sub Component	Stress	Time (hrs)	Sample Size	Dev. Hrs. @ 30°C	No. of Rejects	Failure Rate & Fail Mech.
DS1205S	125°C, Dyn. 7.0V	36	1050	1.89E+07	1	F1
Multi Key	•	1000	231	1.11E+08	O	
	125°C, Dyn. 5,5V	1000	348	1.68E+08	0	
	·		Subtotals	2.98E+08	· 1	7 Fits
AG364	Storage Life	12000		n/a	1%	
Battery	30°C		Subtotals		1%	830
Prnt'd Crkt Board	per MIL-HDBK-217D	2 clip termir	als + Chip on FR4	PC board		
			Subtotals		-	19
				Tabel		856 Fits
				Total		2314 GCG

Package Tests

Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS1991S-R30	Temperature Cycle	1000 ~	225	n/a	0	
	0°C to +70°C, No bias			Total	0	0.0%
	Moisture Soak	960 hr	225	n/a	0	
	60°C/90% R.H. No bias	;		Total	0	0.0%
	Storage Life	1000 hr	225	n/a	0	
	85°C, No Bias			Total	ō	0.0%
DS1991F5 Rev B1	Mechanical Shock	Gp A: 18~/axis	70	n/a	0	
	Mil-Std-883C Method 2002	500g's		Total	0	0.0%
	x1, x2, y1, y2, z1, z2	Gp 8: 18~/axis	10	n/a	0	
		1500g's		Total	0	0.0%
		Gp C: 18~/axis	10	n/a	0	
		3000g's		Total	0	0.0%

Failure Mode	FA #,s	Failure Mechanism	Ea (ev)	B (1/volt)
F1: ICC	None	Not Analysed	0.7	0.43

RELIABILITY PROJECTION

DS1992/3LF50

TOUCH MEMORY

Device Types: DS1992LF50 Rev C1, DS1993LF50 Rev C1

Assembly Technology: Metal Can

Sub Components: D\$2402/3 1/3 Wire EconoRAM, PC Board, BR1225 Battery

Location: Dallas

Package Style: Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

Sub Component (Vehicle)	Stress	Time (hrs)	Sample Size	Equivalent Dev. Hrs. © 55°C, 3.0V	No. of Relects	Failure Rate & Fail Mech.
DS2402/3B4 (DS2404		48	784	1.33E+07	Z Z	F1
1/3 Wire EconoRAM	120 0, 0,1	1000	154	5.18E+07	1	F2
	125°C, Dyn. 5 5V	1000	234	1.76E+07	Ö	, ,
			Subtotal	8.26E+07	3	51 Fits
BR1225	Storage Life	120000		n/a	1%	
Battery	55 ' C		Subtotal		1%	80
Prnt'd Crkt Board	per HOBK 217D	2 clip terminals	+ Chip on PC	C board		
	•	•	Subtotal			19
Total				· · · · · · · · · · · · · · · · · · ·		150 Fits
Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS1994LF50	Temperature Cycle	1000 ~	328	n/a	0	
DS1994LM50	-40°C to +85°C. No bi	ias		Total	0	0.0%
D/C 9231, 9238, 9242, 92	40					
	Moisture Soak	960 hr	360	n/a	0	
	60°C/90% R H. No bia	as		Total	0	0.0%
DS1994LF50	Storage Life	2000 hr	224	n/a	0	
D/C 9207, 9208	85°C. No Bias			Total	0	0.0%
DS1991LF50	Mechanical Shock	Gp A: 18~/axis	70	n/a	0	
D/C 9123, 9131-9136	Mil-Std-883C Method 2002	500g's		Total	0	0.0%
	x1, x2, y1, y2, z1, z2	Gp 8: 18~/axis	10	n/a	O	•
		1500g's		Total	0	0.0%
		Gp C: 18~/axis	10	n/a	a	
		3000gʻs		Total	0	0.0%
DS1991LF50	Vibration	, Cond, A	66	n/a	0	
OS1994LM50 D/C 9211, 9240	Mil-Std-883C Method 2005	10 to 55 Hz 2x.06" /axis		Total	0	0.0%
DS1994LF50	Salt Atmosphere	Cond C	10	n/a	0	
DS1994LM50	Mil-Std-883	96 hr		Total	0	0.0%
D/C 9240 9242	Method 1009					
Failure Mode	FA#,s	Fallure Mechai			Ea (ev	/) B (1/volt)
F1 VccLeak /Comp	92-0104	pch gate oxide	defect	<u> </u>	0.	3 1
F2 VccLeak /Comp/True	93-0074	pch gate oxide	defect		0.	3 1

RELIABILITY PROJECTION DS1993LF50 TOUCH MEMORY W/TIME

Device Types: DS1993LF50

Assembly Technology: Metal Can

Sub Components: DS2403 1/3 Wire EconoRAM, PC Board, BR1225 Battery

Location: Dallas

Package Style: .Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

				Equivalent		
Sub Component		Time	Sample	Dev. Hrs.	No. of	Failure Rate
(Vehicle)	Stress	(hrs)	Size	@ 55°C, 3.0V	Rejects	& Fail Mech.
DS240384 (DS2404)	125°C, Dyn. 7 0V	48	784	1.33E+07	2	<u>F1</u>
1/3 Wire EconoRAM	125°C, Dyn 5.5V	1000 1000	154 234	5.18E+07 1.76E+07	1 0	F2
	125 C. Dyll 5.54	1000	Subtotals	8.26E+07	3	51 Fits
			Subtotals	5.255401	3	21 Fits
BR1225	Storage Life	120000		n/a	1%	
Battery	55°C		Subtotals		1%	80
					_	
Seiko	estimate	n/a	n/a	n/a	n/a	
Crystal			Subtotals			10
Prnt'd Crkt Board	per HOBK 217D	2 clip terminals	+ Chip on PC	board		
	•	•	Subtotals			19
Total				. <u>.</u>		160 Fits
Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent
OS1994LF50	Temperature Cycle	1000 ~	328	n/a	0	Rejected
0013346130	-40°C to +85°C. No bia		320	Total	0	0.0%
	-40 C (0 +03 C, 140 0k	20		i otal	Ü	0.076
	Moisture Soak	960 hr	360	n/a	O	
	60°C/90% R.H. No bia	S		Total	0	0.0%
	Storage Life	2000 hr	224	n/a	0	
	85°C, No Bias			Total	0	0.0%
OS1991LF50	Mechanical Shock	Gp A: 18~/axis	70	n/a	0	
0313316130	Mil-Std-883C	500g's	70	Total	0	0.0%
	Method 2002	00090		, , ,	•	0.07
	x1, x2, y1, y2, z1, z2	Gp B: 18~/axis	10	n/a	0	•
		1500o'c		Total	n	0.0%
					_	
		Gp C. 16-/axis	10	n/a	0	8.897
		3000g's `		Total	U	0.0%
DS1991LF50	Vibration	Cond. A	66	n/a	0	ì
DS1994LM50	Mil-Std-883C	10 to 55 Hz	00	Total	0	0,0%
	Method 2005	2x 06" /axis				
DS1994LF50	Salt Atmosphere	Cond C	10	n/a	0	
DS1994LM50	Mil-Std-883	96 hr		Total	0	0.0%
	Method 1009					•
Failure Mode	FA #.s	Failure Mechae	nism		E	a (ev) B (1/volt)
F1 VccLeak	92-0104	pch gate oxide				0.3
/Comp						
F2 VccLeak	In Analysis					0.3
/Comp/True						

RELIABILITY PROJECTION DS1994LF50 / LM50 TOUCH MEMORY W/TIME

Device Types: DS1994LF50 Rev B5, DS1994LM50 Rev B5

Assembly Technology: Metal Can

Sub Components: DS2404 1/3 Wire EconoRAM, PC Board,

Equivalent

BR1225 Battery, Crystal

Location: Dallas Package Style: Anode/Cathode Tall Flange Can

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

Sub Component	Stress	Time	Sample	Dev. Hrs.	No. of	Failure Rate
DS2404B4	125°C, Dyn. 7.0V	(hrs) 48	Size 784	@ 55°C, 3.5V	Rejects	& Fail Mech.
1/3 Wire EconoRA	•	1000	154	1.08E+09 4.43E+09	2	F1
175 VVIII ECONOTY	125°C, Dyn. 5.5V	1000	234	1.75E+08	1 0	F2
	120 O, Dyll. 3.5V	1000	Subtotal		3	1 Fits
			Subtotal	3.03E+03	3	1 Fits
BR1225	Storage Life	1E+05		n/a	1%	
Battery	55°C		Subtotal	<u> </u>	1%	80
Seiko	estimate	n/a	n/a	n/a	n/a	
Crystal			Subtotal	·	-	10
Prnt'd Crkt Board	per HDBK 217D	2 clip term	ninals + Ch	ip on PC board	l	
			Subtotal			19
Total				1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1		110 Fits
		Maximum	Sample	Failure	No. of	Percent
Vehicle	Stress Type	Stress	Size	Mechanism	Rejects	Rejected
DS1994LF50	Temperature Cycle	1000 ~	328	n/a	0	
DS1994LM50	-40°C to +85°C, No b			Total	0	0.0%
D/C 9231, 9238,	•					0.070
9242, 9240	Moisture Soak	960 hr	360	n/a	0	
	60°C/90% R.H. No b	ias		Total	0	0.0%
					_	
DS1994LF50	Storage Life	2000 hr	224	n/a	0	
D/C 9207, 9208	85°C, No Bias			Total	0	0.0%
DS1991LF50	Mechanical Shock	Gp A: 18	70	n/a	0	
D/C 9123, 9131,	Mil-Std-883C	500gʻs		Total	0	0.0%
9136	Method 2002					
	x1, x2, y1, y2, z1, z2	Gp B: 18	10	n/a	0	
		1500g's		Total	0	0.0%
		.Gp C: 18	10	n/a	0	
		3000g's		Total	0	0.0%
DS1991LF50	Vibration	Cond. A	66	n/a	0	
DS1994LM50	Mil-Std-883C	10 to 55 H	lz	Total	0	0.0%
D/C 9211, 9240	Method 2005	2x.06" /ax	as .			
DS1994LF50	Salt Atmosphere	Cond C	10	n/a	0	
DS1994LM50	Mil-Std-883	96 hr		Total	0	0.C =

D/C 9240, 9242 Method 1009

Failure Mode	FA #,s	•	Failure Mechanism	Ea (ev)	B (1/volt)
F1: VccLeak /Comp	92-0104		pch gate oxide defect	0.3	2.4
F2: VccLeak /Comp/True	93-0074		pch gate oxide defect	0.3	2.4

RELIABILITY PROJECTION DS1996LF50 / LM50 TOUCH MEMORY W/TIME

Device Types: DS1996LF50 Rev A5

Assembly Technology: Metal Can

Sub Components: DS2464 1 & 3 wire 64K SRAM, PC Board, BR1225 Battery Package Style: Anode/Cathode Tall Flange Can

Location: Dallas

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to Field Ambient Temperature and Voltage

Static 6.0V Static 6.0V Static 6.0V Life K 217	Time (hrs) 48 1000 48 1000 48 1000 120000	Sample Size 298 104 311 103 320 114 Subtotal Subtotal Chip on PC	Dev. Hrs. @ 55°C, 3.0V 1.4E+07 9.9E+07 1.4E+07 9.8E+07 1.5E+07 1.1E+08 3.5E+08 n/a	No. of Rejects 5 0 1 1 0 1 8 1%	Failure Rate & Fail Mech. 27 Fits
Static 6.0V Static 6.0V Life	48 1000 48 1000 48 1000 120000	298 104 311 103 320 114 Subtotal Subtotal	1.4E+07 9.9E+07 1.4E+07 9.8E+07 1.5E+07 1.1E+08 3.5E+08	5 0 1 1 0 1 8	27 Fits 80
Static 6.0V Static 6.0V Life	1000 48 1000 48 1000	104 311 103 320 114 Subtotal	9.9E+07 1.4E+07 9.8E+07 1.5E+07 1.1E+08 3.5E+08	0 1 1 0 1 8	80
Static 6.0V Life	48 1000 48 1000 120000	311 103 320 114 Subtotal Subtotal	1.4E+07 9.8E+07 1.5E+07 1.1E+08 3.5E+08	1 1 0 1 8	80
Static 6.0V Life	1000 48 1000 120000	103 320 114 Subtotal Subtotal	9.8E+07 1.5E+07 1.1E+08 3.5E+08	1 0 1 8	80
Life	48 1000 120000	320 114 Subtotal Subtotal	1.5E+07 1.1E+08 3.5E+08	0 1 8	80
Life	120000	114 Subtotal Subtotal Chip on Po	1.1E+08 3.5E+08 n/a	1 8 1%	80
	120000	Subtotal Subtotal Chip on Po	3.5E+08 n/a	8 1%	80
	4	Subtotal	n/a	1%	80
	4	Chip on Po			
K 217	2 clip terminals	Chip on Po	C board	1%	
K 217	2 clip terminals		C board		
	•		·		
					19
					99 Fits
					33 FI(3
уре	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
iture Cycle	1000 ~	328	n/a	0	
		020			0.0%
	_		1 0 121	•	0.07.
Soak	960 hr	360	n/a	0 .	
			Total	0	0.0%
Life ·	2000 hr	224	n/a	0	
			Total	0	0.0%
cal Shock	Go A: 18~/axis	70	n/a	0	
383C	500g's		Total	0	0,0%
	Ca D: 19. (avia	10	-1-	0	
1, 92, 21, 22	•	10			0.0%
	150093		TOTAL	•	0.07
	Go C: 18~/axis	10	n/a	0	
			Total	ō	0.0%
١	Cond. A	66	n/a	0	
383C	10 to 55 Hz		Total	0	0.0%
2005	2x.06" /axis				
osphere	Cond C	10	n/a	0	
883	96 hr		Total	0	0.0%
1009					
Fail	ure Mechanism			Ea (ev)	B (1/volt)
ss n/a				0.7	1
/al. High	h Current Conditio	on/EOS. (1	Fest Induced/escape)	n/a	n/a
Gat	e Oxide Defect		•	0.7	1
. Higi	h Current Conditio	on/EOS. (1	Fest Induced/escape)	n/a	n/a
_		,	, ,	0.7	1
	+85°C, No bias Soak R.H. No bias Life o Bias ical Shock 883C 2002 1, yZ, z1, z2 1, yZ, z1, z2	+85°C, No bias Soak 960 hr % R.H. No bias Life 2000 hr o Bias ical Shock Gp A: 18~/axis 883C 500g's 2002 1, y2, z1, z2 Gp B: 18~/axis 1500g's Gp C: 18~/axis 3000g's Cond. A 883C 10 to 55 Hz 2005 2x.06° /axis icasphere Cond C 883 96 hr 1009 Failure Mechanism SS n/a val. High Current Condition Gate Oxide Defect High Current Condition	+85°C, No bias Soak 960 hr 360 % R.H. No bias Life 2000 hr 224 o Bias ical Shock Gp A: 18~/axis 70 B83C 500g's 2002 1, y2, z1, z2 Gp B: 18~/axis 10 1500g's Gp C: 18~/axis 10 3000g's Cond. A 66 883C 10 to 55 Hz 2005 2x.06° /axis icasphere Cond C 10 883 96 hr 1009 Failure Mechanism SS n/a val. High Current Condition / EOS. (3) Gate Oxide Defect High Current Condition / EOS. (6)	#85°C, No bias Soak 960 hr 360 n/a % R.H. No bias Total Life 2000 hr 224 n/a o Bias Total Life 2000 hr 224 n/a o Bias Total Indicates Total I	#85°C, No bias Soak 960 hr 360 n/a 0

RELIABILITY PROJECTION DS2400/DS914

Product Types:

DS2400/DS914

Date Codes:

9045, 9049, 9107

Process Technology

Si Gate CMOS

Channel Length: 1.2 µ

Metal Pitch: 3.0 µ

Assembly Technology:

See Below

Summary Data with Chi-Squared Distribution Assumed: Ea = 0.7 ev & B = 1.0 Stress Ambient Temperature to Field Ambient Temperature Stress Voltage to Use Voltage

				Equivalent		
		Time	Sample	Dev. Hrs.	No. of	Failure Rate
Vehicle	Stress	(hrs)	Size	@ 55°C, 5.5 V	Rejects	& Fail Mech.
DS914 A1	125°C, 7.0 V, Dyn.	48	1394	2.33E+07	1	F1
Touch Mem Ch	nip	96	898	3.00E+07	0	
D/C 9045, 9049	, 9107	1000	444	1.47E+08	0	
	125°C, 5.5 V, Dyn	1000	444	3.27E+07	0	
DS914 A2	125°C, 7.0 V, Dyn.	504	196	3.43E+07	0	
Touch Mem Ch	nip					
D/C 9143						
Totals				2.67E+08	1	8 Fits

Package Tests 8 PDIP, Anam, K.

Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS2400	Temperature Humidity	1000 hr	348	n/a	Ŏ.	
	85°C/85% R.H., 5.5V			Total	0	0.0%
			TO92, 3L	D, Carsem		
DS2223	Temperature Cycle	1000 ~	166	n/a	0	
	-\$5°C to +125°C, No bia		Total	0	0.0%	
DS2223	HAST	200 hr	153	n/a	0	
	120°C/85% R.H. 5.5 V.			Total	0	0.0%
DS2223	Storage Life	1khr	166	n/a	0	
	150°C, No Bias			Total	0	0.0%

Failure Me	echanism	Corrective Action
F1	Read Type Id	None

RELIABILITY PROJECTION 0S24S03

Device Type: DS24S03 Rev A3, A4

Process Tech: 0.8µ CMOS

Metal Pitch: 2.0 μ Die Size: 89 X 97 mil**2 Passivation: 10K Ox / 6K Ni Metal Type: Al / 0.8% Si / 0.5% Cu Metal Width: 0.8 μ Xstr Count: 2180 Channel Length: 0.8 μ Gate Oxide Thickness: 175 Å

Summary Data with Chi-Squared Distribution Assumed Stress Ambient Temperature and Voltage (125°C, 5.5V, 6.0V or 7.0V) to Field Ambient Temperature and Voltage (55°C, 3.5V) Voltage and Temperature Acceleration as noted below

				Equivalent		
Vehicle	Stress	Time (hrs)	Sample Size	ev. Hrs. @ 55°C, 3.50 V	No. of Rejects	Failure Rate & Fail Mode
DS24S03 A3	125°C, Static 6.0V	48	340	4.3E+07	2	2-F1
D/C 9427		336	115	1.0E+08	1	F2
		1000	114	3.0E+08	0	
DS24S03 A3	125°C, Static 6.0V	48	320	4.0E+07	0	
D/C 9451		336	115	1.0E+08	1	F3
		1000	114	3.0E+08	0	
Totals				9E+08	4	6 Fits

Assy Tech: Sumitomo 6300H Plasti Assembly Site: Anam, Pl

Die Attach: Silverfilled Epoxy Lead Frame: Cu w/Solder Plate Package: PDIP

Pad Size: 110 X 140 mil**2

No. Pins: 16

Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS24S03 A3	Temperature Cycle	1000 ~	151	n/a	0	
D/C 9427, 945	-55°C to +125°C		Total		0	0.0%
	Temp. Humidity Bias	959 hr	152	n/a	0	
	85°C/85% R.H., 5.5V		Total		0	0.0%
	Autoclave	168 hr	90	n/a	0	
	121°C, 2Atmos, No bia	as	Total		0	0.0%

Failure Mode FA#	Failure Mechanism	Ea	В
F1 Batt Leaka 94-0121	Gate Oxide Defect	0.3	2.4
F2: Chkrbrd Tr 94-0120	Gate Oxide Defect	0.3	2.4
F3: Batt Leaka 95-0077	Gate Oxide Defect	0.3	24

RELIABILITY PROJECTION DS2404 / DS1608

Product Types: DS2404 Rev B4, DS1608 Rev B4

Process Technology: Si gate CMOS Die Size: 136 X 175 mil

Metallization: Al/1.0% Si/0.5% Cu

Passivation: Nitride

Transistor Count: 45191

Metal Pitch: 3.0μ Channel Length: $1.2~\mu$

Summary Data with Chi-Squared Distribution Assumed @ 60%CF and Ea, B as assigned below Stress Ambient Temperature and Voltage to

Field Ambient Temperature and Voltage

				Equivalent		
Vehicle	Stress	Time (hrs)	Sample Size	Dev. Hrs. @ 55°C, 5.5∨	No. of Rejects	Failure Rate & Fail Mech.
DS2404B4	125°C, Dyn. 7.0V	48	1871	3.39E+07	2	F1
D/C 9236, 9244, 9	9301	500	347	5.92E+07	0	. ,
		1000	231	4.36E+07	1	F2
	125°C, Dyn. 5.5V	1000	348	2.14E+06	0	`-
DS1608B4	125°C, Dyn. 7.0V	48	1749	2.80E+08	ō	
D/C 9301		336	232	2.52E+07	1	F3
Totals				4.44E+08	4	12 Fits

Assembly Tech: Plastic Package Style: SOIC

No. Pins: 16

Assembly Site: ANAM, K

Pad Size: 160 X 200 mil

Lead Frame: Cu w/ Solder Plate

Vehicle	Stress Type	Maximum Stress	Sample Size	Failure Mechanism	No. of Rejects	Percent Rejected
DS2404 S	Preconditioning				,	rejected
D/C 9236, 9244	T/C: -55°C to +125°C	5~	794	n/a	0	
	THB: 85°C/85% R.H.	137 hr		****	Ū	
	HTC Vapor Phase	2X, 220°C		Total	0	0.0%
	Temperature Cycle	1000 ~	229	n/a	0	
	-55°C to +125°C	+125°C		Total	0	0.0%
	Autoclave	168 hr	135	n/a	0	
	121°C, 2 At. Unbiased			Total	0	0.0%
	Temperature Humidity	959 hr	231	n/a	0	
	85°C/85% R.H., 5.5V			Total	0	0.0%

Vehicle	Package Test	X-Ray	Phys Dim.	Mark, Perm.	Solderability	Lead Integrity
DS2404S	Total Samples	10	10	10	48	48
D/C 9236, 9244	Total Faits	0	0	0	o	0

Failure Mode	FA #,s	Failure Mechanism	Ea (ev)	B (1/volt)
F1: VccLeak /Comp	92-0104	pch gate oxide defect	0.30	27
F2: VccLeak /Comp/True	93-0074	pch gate oxide defect	0.30	2.7
F3: Parity Hi Vcc	In Analysis	(pch gate oxide defect)	0.30	2.7

RELIABILITY PROJECTION **DS2464**

Device Type: DS2464 Rev B3

Process Tech: 0.8 µ CMO\$

Metal Pitch: 2,0 µ

Die Size: 160 X 204 mil™2

Metal Width: 0.8 µ Xstr Count: 56200

Metal Type: Al / 0.8% Si / 0.5% Cu Gate Oxide Thickness: 175 A

Passivation: 10K Ox / 6K Ni

Channel Length: 0.8 µ

Summary Data with Chi-Squared Distribution Assumed Stress Ambient Temperature and Voltage (125°C, 5.5V, 6.0V or 7.0V) to Field Ambient Temperature and Voltage (55°C, 5.5V) Voltage and Temperature Acceleration as noted below

Vehicle D02464 D0	Stress	Time (hrs)	Sample Size	Equivalent Dev. Hrs. @ 55°C, 3.50 V	No. of Rejects	Failure Rate & Fail Mode
DS2464 B3	125°C, Static 6.0V	48	298	3.7E+07	5	F1, F2, F3, 2-F4
D/C 9530		1000	104	2.7E+08	ō	F1, F4, F3, 2-F4
D\$2464 A2	125°C, Static 6.0V	48	311	3.9E+07	•	
D/C 9449		1000	103	2.7E+08		F5
DS24S03 A3	125°C. Static 6.0V	48	320	· ·	1	F6
D/C 9451	,	1000		4.0E+07	0	
Totals		1000	114	3.0E+08	_1	F7
				1E+09	8	10 Fits

Assy Tech: Sumitomo 6300H Plastic Assembly Site: Hundai / Omedata

Package: 300 mil PD(P

No. Pins: 24

Die Attach: Silverfilled Epoxy

Lead Frame: A42 w/Solder Plate

Pad Size: 225 X 390 mil**2

Maximum Sample Failure No. of Percent Vehicle Stress Type Stress Size Mechanism Rejects Rejected DS2464 B3 Temperature Cycle 1000 ~ 154 n/a 0 D/C 9530 -55°C to +125°C Total 0 0.0% D\$2464 A2 D/C 9449 Temp. Humidity Bias 959 hr 153 F7 85°C/85% R.H., 5.5V Total 0.7% Autoclave 168 ñr 85 n/a 0 121°C, 2Atmos, No bias Total 0.0%

Failure Mode	FA#	Failure Mechanism	_	
F1: Vccleak True	95-0163		Ea	В
F2: Checkbd Hi V			0.3	2.4
F3: Icc Active	95-0163		0.3	2.4
F4: IO Resistance			0.3	2.4
F5: VCCLeak Tru			0.3	2.4
F6: VCCLeak Cor		Gate Oxide Defect	0.3	2.4
F7: VCCLeak Tru		Gate Oxide Defect	0.3	2.4
		Gate Oxide Defect	0.3	2.4
F8: Static	95-0077	Gate Oxide Defect	0.3	2.4

RELIABILITY PROJECTION DS2505

Preliminary Release

Device Type: DS2505 Rev A3

Proc. Tech.: 0.8µ CMOS

Metal Pitch: 2.2 µ

Metal Width: 1.2 น Xstr Count: ~6400 Metal Type: Al / 1% Si / 0.5% Cu

Die Size: 77 X 114 mil Passivation: Oxide / OxyNitride Channel Length: 0.8 µ

Gate Oxide Thickness: 175A

Summary Data with Chi-Squared Distribution Assumed Stress Ambient Temperature and Voltage (125°C, 5.5V or 7.0V) to Field Ambient Temperature and Voltage (55°C, 5.5V) Voltage and Temperature Acceleration as noted below

		Equivalent						
		Time	Sample	Dev. Hrs.	No. of	Failure Rate		
Vehicle	Stress	(hrs)	Size	@ 55°C, 5.5 V	Rejects	& Fail Mech.		
DS2505 A3	125°C, Dyn. 7.0V	48	347	5.8E+06	0	• • • • • • • • • • • • • • • • • • • •		
D/C 9449		336	116	1.4E+07	0			
		1000	116	2.7E+07	0			
Totals				4.6E+07	0	20 Fits		
				Equivalent				
		Time	Sample	Dev. Hrs.	No. of	Failure Rate		
Vehicl e	Stress	(brs)	Size	@ 55°C	Rejects	& Fail Mech.		
DS2505 A3	150°C, Storage Life	1000	77	2.2E+08	0			
D/C 9449	Data Retention							
Totals		· · · · · · · · · · · · · · · · · · ·		2.2E+08	0	4 Fits		

Assembly Technology: Shinetsu 184

Site: Anam, Pf

Package: 170 mil TSSOP

Lead Frame: C7025 Cu

Pad Size: 118 X 165 mil-2 Die Attach: Ag filled Ablebond 84-1 LMISR4 Epoxy

Vehicle	Stress Type	Maximum Stress	Sampl e Size	Failure Mechanism	No. of Rejects	Percent Rejected
D\$2107A A5	Preconditioning	*				
D/C 9306, 7	T/C: -55°C to +125°C	5~	_ 897		0	
	THB: 85°C/85% R.H.	137 hr			0	
	Vapor Phase Reflow	2X, 230°C —	·	Total	0	0.0%
	Temperature Cycle	1000 ~	230		0	
	-55°C to +125°C			Total	0	0.0%
	Temperature Humidity	959 hr	229	n/a	o	
	85°C/85% R.H., 5.5V			Total	0	0.0%
	Autoclave	168 hr	132	n/a	0	
	121°C, 2Atmos, No bias			Total	0	0.0%

Vehicle	Package Test:	X-Ray	Phys Dim	Mrk. Prm.	Solderability	Lead Integrit	y Sonoscan
DS2107A A5	Total Samples	15	15	15	72	72	6
O/C 9306, 7	Total Fails	0	0	0	0	0	0